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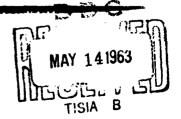
FREQUENCY TEMPERATURE
COMPENSATION TECHNIQUES

FOR

QUARTZ CRYSTAL OSCILLATORS

SECOND QUARTERLY REPORT

PIONEER-GENTRAL DIVISION DAVENPORT, IOWA THE Bendix



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Prepared by The Bendix Corporation Pioneer-Central Division Davenport, Iowa

#### RESEARCH WORK FOR

FREQUENCY TEMPERATURE COMPENSATION

TECHNIQUES FOR QUARTZ CRYSTAL OSCILLATORS

in conjunction with Signal Corps

Technical Requirements SCL-6610

dated November 1961

SECOND QUARTERLY REPORT FOR

PERIOD 1 OCTOBER 1962 to 31 DECEMBER 1962

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REPORT NO.2

Object of Research: The design and development of circuit techniques for oven-less crystal oscillators having frequency temperature stabilities previously achieved in temperature stabilized oscillators consuming several watts of power

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# TABLE OF CONTENTS

| I | Section | Title                                 | Page |
|---|---------|---------------------------------------|------|
| T | 1.1     | Purpose                               | 1.1  |
| L | 2.1(a)  | Abstract                              | 2.1  |
| T | 2.1(b)  | Conferences                           | 2.1  |
| r | 3.1     | Varicap Compensation Method           | 3.1  |
| I | 3.2     | Transistor Compensation Method        | 3.25 |
| T | 3.3     | Binistor Compensation Method          | 3.43 |
| I | 3,4     | Capacitor-Diode Compensation Method   | 3.45 |
| I | 3.5     | Diode Voltage Control and Switching   | 3.67 |
| 1 | 3,6     | Oscillator Aging Tests                | 3.77 |
| I | 4.1     | Conclusions                           | 4.1  |
| I | 5.1     | Personnel Associated With the Project | 5.1  |

# TABLE OF FIGURES

| Figure No. | Title  | Page No |
|------------|--|---------|
| 3.1.1      | Two Varicap Compensation Circuit                     | 3.1     |
| 3.1.2      | Compensation Capacitance Vs Temperature              | 3.2     |
| 3.1.3      | Compensation Networks                                | 3.4     |
| 3.1.4      | Correction Curves to Eliminate Interaction           | 3.4     |
| 3.1.5      | Zener Control to Two Varicap Compensation Network    | 3.6     |
| 3.1.6      | Two Diode Parallel Compensation Network              | 3.7     |
| 3.1.7      | Bridge Compensation Network                          | 3.8     |
| 3.1.8      | Basic Oscillator Configuration                       | 3.12    |
| 3.1.9      | Frequency Deviation Vs Voltage                       | 3.13    |
| 3.1.10     | Frequency Deviation Vs Temperature                   | 3.14    |
| 3,1,11     | Two Varicap Compensated Oscillator                   | 3.16    |
| 3.1.12     | Frequency Deviation Vs Resistance                    | 3.17    |
| 3,1,13     | Frequency Deviation Vs Resistance                    | 3.18    |
| 3,1,14     | Frequency Deviation Vs Temperature                   | 3.19    |
| 3.1.15     | Typical Bridge Circuit Used for Compensation Studies | 3.20    |
| 3.1.16     | Frequency Deviation Vs Resistance                    | 3,21    |
| 3.1.17     | Frequency Deviation Vs Resistance                    | 3.23    |
| 3.1.18     | Comparison of Bridge and Voltage Divider             | 3,24    |
| 3.2.1      | Schematic of Oscillator Used for Transistor Method   | 3.26    |
| 3.2.2      | Frequency Deviation Vs Resistance                    | 3.28    |
| 3.2.3      | Frequency Deviation Vs Resistance                    | 3.29    |
| 3.2.4      | Frequency Deviation Vs Resistance                    | 3.30    |
| 3.2.5      | Frequency Deviation Vs Resistance                    | 3.31    |
| 3.2.6      | Frequency Deviation Vs Resistance                    | 3.32    |

| <u>[</u> |            |   |          |
|----------|------------|---|----------|
| T        | Figure No. | <u>Title</u>                                      | Page No. |
| l        | 3.2.7      | Frequency Deviation Vs Resistance                 | 3.33     |
| T        | 3.2.8      | Frequency Deviation Vs Resistance                 | 3,34     |
| L        | 3,2,9      | Frequency Deviation Vs Resistance                 | 3.35     |
| I        | 3.2.10     | Frequency Deviation Vs Resistance                 | 3.36     |
| T        | 3.2.11     | Frequency Deviation Vs Resistance                 | 3.37     |
| 1        | 3.2.12     | Frequency Deviation Vs Resistance                 | 3.38     |
| T        | 3.2.13     | Frequency Deviation Vs Resistance                 | 3.39     |
| _        | 3.3.1      | Binistor Configuration                            | 3.43     |
| I        | 3.4.1      | Diode Compensation Networks                       | 3.45     |
| T        | 3.4.2      | Capacitor-Diode Compensation Circuit              | 3.46     |
| 1        | 3.4.3      | Frequency Deviation Vs Voltage                    | 3.48     |
| I        | 3.4.4      | Frequency Deviation Vs Voltage                    | 3.50     |
|          | 3.4.5      | Frequency Deviation Vs Temperature                | 3.53     |
| I        | 3.4.6      | Schematic for Capacitor-Diode Compensation Method | 3.54     |
| τ        | 3.4.7      | Frequency Deviation Vs Resistance                 | 3.55     |
| 1.       | 3.4.8      | Frequency Deviation Vs Resistance                 | 3.56     |
| T        | 3.4.9      | Frequency Deviation Vs Resistance                 | 3.57     |
| 1        | 3.4.10     | Calculated Resistance Vs Temperature              | 3,59     |
| I        | 3.4.11     | Frequency Deviation Vs Temperature                | 3.60     |
| T        | 3.4.12     | Frequency-Temperature Curves - Generalized        | 3.61     |
| l        | 3.4.13     | Frequency Deviation Vs Temperature                | 3.62     |
| I        | 3.4.14     | Calculated Frequency Deviation Vs Temperature     | 3.63     |
| 1        | 3.4.15     | Frequency Deviation Vs Resistance                 | 3.65     |
| I        | 3.5.1      | Bridge Circuit                                    | 3.67     |
| T        | 3.5.2      | Measured Current Vs Voltage                       | 3.69     |
| 1        | 3.5.3      | Characteristics of Bridge Circuit                 | 3.70     |
| _        |            |   |          |

| Figure No. | <u>Title</u>   | Page No. |
|------------|--|----------|
| 3.5.4      | Voltage Vs Resistance                                | 3.71     |
| 3.5.5      | Voltage Vs Resistance                                | 3.72     |
| 3.5.6      | Voltage Vs Resistance                                | 3.74     |
| 3.5.7      | Diode Voltage Vs Resistance                          | 3.75     |
| 3,6,1      | Aging Curves for Temperature Compensated Oscillators | 3.79     |
| 3.6.2      | Frequency Deviation Vs Temperature                   | 3.82     |
| 3.6.3      | Frequency Deviation Vs Temperature                   | 3.83     |
| 3.6.4      | Frequency Deviation Vs Temperature                   | 3.84     |
| 3.6.5      | Frequency Deviation Vs Temperature                   | 3,85     |

## 1.1 Purpose

The purpose of this project is to evolve a practical analytical and empirical approach to the temperature compensation of a quartz crystal oscillator. The study will encompass numerous methods of compensation, of which the most promising will be investigated fully and complete design procedure obtained. The study will be concentrated on a nominal frequency of three megacycle, but will be generally applicable to AT cut quartz crystal of from 1 to 20 megacycles.

#### 2.1(a) Abstract

The different methods of frequency-temperature compensation (varicap, transistor and isolation stage, binistor, and capacitor-diode) are discussed. New techniques and approaches to compensation of crystal oscillators are presented, and mathematical analyses are developed for each. Empirical data is presented indicating the characteristics of each compensation method. A method of obtaining negligible effect of B+ voltage changes is presented.

Several new approaches to voltage control networks are discussed, including a bridge voltage and current control network that is applicable to both the varicap and capacitor-diode method.

Aging data on four oscillators is presented which is a continuation of the aging tests started during the first quarter of this contract. The aging oscillators were temperature cycled and the original frequency-temperature characteristics were compared to the characteristics obtained.

#### 2.1(b) Conferences

Mr. Owen P. Layden of the Signal Corps visited Pioneer-Central Division of The Bendix Corporation on 12 December 1962. During this conference progress on Contract No. DA36-039 SC-90782 was reviewed.

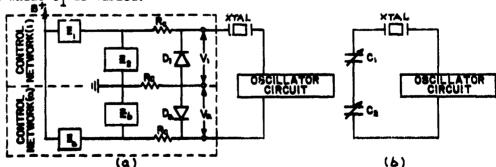
After reviewing the progress, Mr. Layden suggested several circuit modifications be investigated with the results shown in subsequent reports.

The conference also included the proposed investigation efforts for the third quarter.

### 3.1 Varicap Method

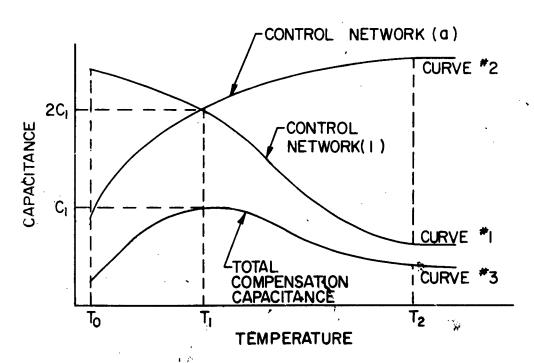
The First Quarterly Report contained the basic theory of the varicap method. During the second quarter, emphasis has been placed on investigation of the characteristics of compensation techniques and circuit designs. Investigation was conducted on the use of two varicaps and compensation networks, a bridge compensation circuit with a varicap, and zener diode control of voltages generated by thermistor-resistor networks. Effort was also conducted on optimizing the oscillator circuit parameters and on investigating the required compensation networks using different cuts of crystals and different values of varicaps.

The idea of utilizing two varicaps and two compensation networks has been investigated. The following circuit, Figure 3.1.1(a) illustrates an oscillator using this method.  $D_1$  and  $D_a$  are voltage variable capacitors.  $Z_1$  and  $Z_2$  are the voltage control elements for  $D_1$ , and  $Z_a$  and  $Z_b$  are the voltage control elements for  $D_a$ , Figure 3.1.1(b) is the equivalent electrical diagram for Figure 3.1.1(a). The variable capacitance,  $C_1$ , is the capacitance of diode  $D_1$  controlled by  $Z_1$  and  $Z_2$  and the variable capacitance,  $C_2$ , is the capacitance of diode  $D_a$  controlled by  $Z_a$  and  $Z_b$ .  $C_1$  and  $C_2$  are independent of each other.  $C_1$  can be made constant while  $C_2$  is varied or  $C_2$  can be made constant while  $C_1$  is varied.



TWO VARICAP COMPENSATION CIRCUIT Figure 3.1.1

Figure 3.1.2, Curve #3, is a typical plot of C versus temperature that is required to compensate an AT cut crystal. The difficulty encountered when using only one varicap and thermistor network,  $\mathbf{Z}_1$  and  $\mathbf{Z}_2$ , is that to generate the slope from temperature  $\mathbf{T}_0$  to  $\mathbf{T}_1$  requires the thermistor-resistor network resistance of  $\mathbf{Z}_2$  to decrease very rapidly with temperature. The change in slope at temperature  $\mathbf{T}_1$  and from  $\mathbf{T}_1$  to  $\mathbf{T}_2$  requires that  $\mathbf{Z}_1$  decrease very rapidly with temperature. The decrease in  $\mathbf{Z}_1$  must also offset the decrease in  $\mathbf{Z}_2$  past  $\mathbf{T}_1$ , just as the increase in  $\mathbf{Z}_2$  must offset the increase in  $\mathbf{Z}_1$  below  $\mathbf{T}_1$ . This interaction of  $\mathbf{Z}_1$  and  $\mathbf{Z}_2$  around the temperature  $\mathbf{T}_1$  makes the matching of the curve around the  $\mathbf{T}_1$  temperature difficult in many cases. By using two independent control elements, this problem can be reduced or even eliminated.



COMPENSATION CAPACITANCE VS TEMPERATURE FOR TWO VARICAP COMPENSATION METHOD Figure 3.1.2

The equivalent capacitance of the two diodes shown in Figure 3.1.1(a) can be expressed as follows.  $K_1$  and  $K_2$  are constants determined by the type of diode used.

1) 
$$c_x = \frac{c_1 c_a}{c_1 + c_a}$$

2) 
$$c_1 = \frac{\kappa_1}{\sqrt{v_1}}$$

3) 
$$C_a = \frac{K_a}{\sqrt{V_a}}$$

4) 
$$C_x = \frac{1}{\sqrt{\frac{V_a}{K_a}} + \sqrt{\frac{V_1}{K_1}}}$$

Assume that  $D_1$  has control from  $T_0$  to  $T_1$  and  $D_a$  has control from  $T_1$  to  $T_2$ . Then the curve of capacitance versus temperature for each one must be as shown in Figure 3.1.2, Curves #1 and #2. As can be seen, the slope of C versus temperature must change magnitude rather abruptly, but the slope does not have to change sign as in the one varicap compensation circuit. As indicated in Figure 3.1.3(a), only one thermistor network in each compensation circuit is required to generate  $C_1$  and  $C_2$  versus temperature curves similar to the ones shown in Curves #1 and #2 of Figure 3.1.2. Although only one thermistor network may be required, the change in capacitance may be difficult to generate at  $T_0$ . Therefore, thermistor networks,  $Z_1$  and  $Z_b$ , are included for  $R_1$  and  $R_b$  as shown in Figure 3.1.3(b).  $Z_1$  does not have any effect below  $T_1$ , and  $T_2$  does not have any effect above  $T_1$ . The only function performed by  $T_1$  and  $T_2$  is to maintain  $T_2$  constant or nearly constant when either compensating capacitor goes beyond its specified temperature range.

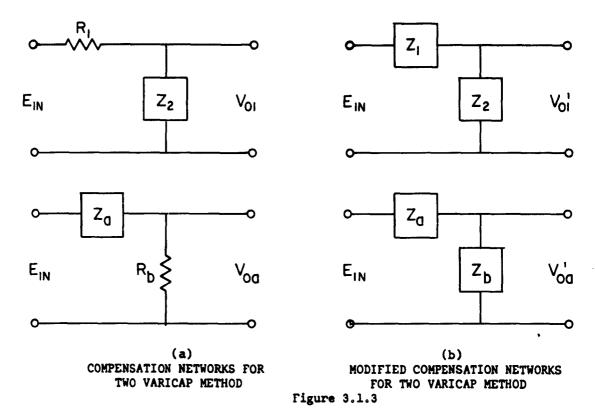


Figure 3.1.4 illustrates the purpose of  $Z_1$  at temperature above  $T_1$ .

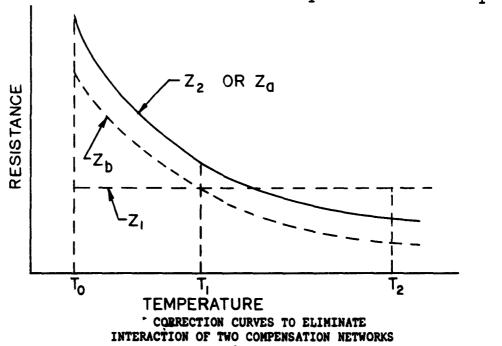


Figure 3.1.4

At  $T_1$  and above, where  $C_1$  is required to be constant,  $Z_1$  changes in such a manner that the change in  $Z_2$  is cancelled. The following equations show the relationship that must exist between  $Z_1$  and  $Z_2$  from  $T_1$  and  $T_2$ .

5) 
$$V_0 = \frac{Z_2}{Z_1 + Z_2}$$
 (E)

6) 
$$\frac{dV_0}{dZ_1} = \frac{Z_1}{(Z_1 + Z_2)^2}$$
 (E)

7) 
$$\frac{dV_0}{dz_1} = \frac{z_2}{(z_1 + z_2)^2}$$
 (E)

To maintain Vo constant from T1 and T2,

**b**.

8) 
$$\frac{z_1(dz_2)}{(z_1+z_2)^2}$$
 (E) =  $\frac{z_2(dz_1)}{(z_1+z_2)^2}$  (E)

9) 
$$\frac{dz_1}{dz_2} = -\frac{z_1}{z_2}$$

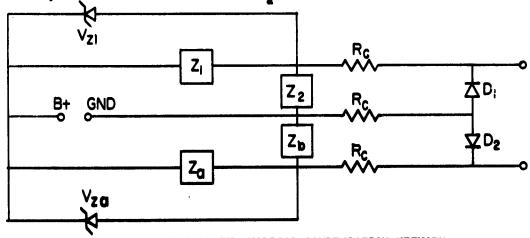
Therefore, the rate of change of  $Z_1$  with respect to  $Z_2$  must be  $(-Z_1/Z_2)$  to maintain a constant voltage,  $V_0$  is shown by Equation 10.

10) 
$$dz_1 = -\frac{z_1}{z_2} (dz_2)$$

The problem now reduces to providing a thermistor-resistor network that does not vary from T $_0$  to T $_1$  and changes at the rate of  $-z_1/z_2(dz_2)$  from T $_1$  to T $_2$ .

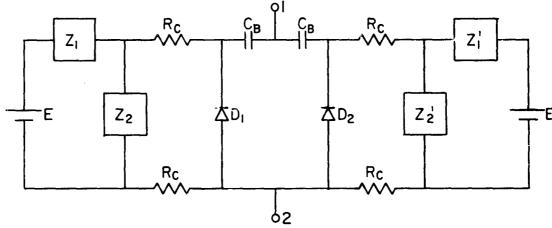
Equation 10 can be rather complicated if  $Z_1$  is different in magnitude by a larger factor than  $Z_2$  at  $T_0$ , but if, as is usually the case,  $Z_1$  is approximately of the same magnitude as  $Z_2$ , then the ratio of  $-Z_1/Z_2$  at  $T_1$  can be used for  $(-Z_1/Z_2)$  from  $T_1$  to  $T_2$  with little effect. The analysis presented above can be used to determine the requirements for  $Z_1$  and  $Z_1$ .

A possible method of generating the required capacitance versus temperature curves shown in Figure 3.1.2 is to use zener diodes in the compensating networks. Figure 3.1.5 is an example of how zener diodes can be used to generate the required voltage versus temperature curves. The operation of a single compensating circuit using zener-diode control was explained in the First Quarterly Report. As  $Z_2$  decreases in resistance with temperature, the voltage across  $Z_1$  increases to some value  $V_1$ . If the zener diodes has its knee at  $V_1$ , then the voltage cannot increase beyond  $V_1$  and  $V_0$  remains constant at temperatures above  $T_1$ . As  $Z_2$  increases as temperature decreases, the voltage  $V_{02}$  decreases and the voltage across  $Z_2$  increases to some maximum voltage,  $V_2$ . At the temperature  $T_1$ ,  $V_{02}$  has decreased to its minimum value. If the zener diode across  $Z_2$  is at  $V_2$ , then the output  $V_{02}$  cannot decrease further, but remain constant at  $(E - V_2)$ .



ZENER CONTROL OF TWO VARICAP COMPENSATION NETWORK Figure 3.1.5

Another two varicap method that can be used for compensation is to parallel the varicaps as shown in Figure 3.1.6. D<sub>1</sub> and D<sub>2</sub> are varicaps, the Rc's are decoupling resistors; the  $C_B$ 's are d-c blocking capacitors and



TWO DIODE PARALLEL COMPENSATION NETWORK Figure 3.1.6

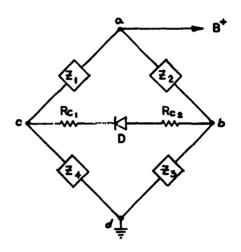
 $Z_1$ ,  $Z_2$ ,  $Z_1$  and  $Z_2$  are the temperature sensitive control networks. The equation for the capacitance at the terminals 1-2 is simply:

11) 
$$c_x = c_1 + c_2$$

Assuming that the capacitance to be simulated by this network is as shown in Figure 3.1.2, Curve #3, the individual capacitance could vary with temperature in a similar manner as shown in Figure 3.1.2, Curves #1 and #2, but the magnitude of each individual network will be about one fourth as much as shown for the series network. The same reasoning as used for the series varicap method can be used to show that zener diode control will be advantageous around the temperature T<sub>1</sub>.

Due to the fact that only voltage divider circuits have been considered for compensation, operation of the varicap at zero bias or even a positive bias has not been considered, since it is difficult to generate a voltage very close to zero and have flexibility in choosing the voltage divider components.

To generate a zero bias with a voltage divider either  $Z_1$  has to approach infinity or  $Z_2$  has to be zero. Both of these cases impose requirements that are too extreme on the components. To eliminate these requirements a bridge circuit as shown in Figure 3.1.7 was tried, where diode  $D_1$  is a varicap,  $R_{c1} = R_{c2}$  and are isolating resistors;  $Z_1$ ,  $Z_2$ ,  $Z_3$  and  $Z_4$  are variable bridge variable resistances.



BRIDGE COMPENSATION NETWORK Figure 3.1.7

The varicap can be biased slightly positive, and negative to values approaching B+. When biased in the forward range the voltage that can be applied to the varicap is limited because the diode begins conducting heavily at relatively small forward bias voltages. Although the forward voltage of the diode is limited by the diodes forward characteristics, the impedance exhibited by the diode will vary quite appreciably. This will enable the varicap to be used for compensation when biased slightly in the forward direction.

The following analysis of the bridge compensation networks was done using the circuit shown in Figure 3.1.7.

 $R_{t} = Z_{t} = 2R_{c} + R_{D}$  where  $R_{D}$  is the varicap DC resistance. Equations 12 through 23 indicate the derivation of Equations 24 and 25. Equations 24 and 25 are the equations for the diode current and voltage as a function of the circuit parameters and the diode DC resistance.

12) 
$$0 = i_a (z_1 + z_2 + z_T) + i_b (z_T) + iz_1$$

13) 
$$0 = i_a (Z_T) + i_b (Z_3 + Z_4 + Z_T) - iZ_4$$

14) 
$$E = i_a Z_1 - i_b Z_4 + i (Z_1 + Z_4)$$

15) 
$$i = -i_a \left(1 + \frac{z_2}{z_1} + \frac{z_T}{z_1}\right) - \frac{i_b z_T}{z_1}$$

16) 
$$i_a = \frac{-i_b \left(z_3 + z_4 + z_T + \frac{z_4 z_T}{z_1}\right)}{z_T + \frac{z_4}{z_1} \left(z_1 + z_2 + z_T\right)}$$

17) 
$$E = i_a(z_1-z_1-z_4-z_2-\frac{z_2z_4}{z_1}-z_1-\frac{z_4z_T}{z_1}) - i_b(z_4+z_T+\frac{z_4z_T}{z_1})$$

18) 
$$E = \frac{i_b(z_3 + z_4 + z_T + \frac{z_4 z_T}{z_1}) (z_4 + z_2 + \frac{z_2 z_4}{z_1} + z_T + \frac{z_4 z_T}{z_1})}{z_T + \frac{z_4}{z_1} (z_1 + z_2 + z_T)} - i_b(z_4 + z_T + \frac{z_4 z_T}{z_1})$$

19) E = 
$$\frac{i_b(z_1 z_3 z_4 + z_1 z_2 z_3 + z_2 z_3 z_4 + z_1 z_3 z_T + z_3 z_4 z_T + z_1 z_2 z_4 + z_1 z_2 z_T + z_2 z_4 z_T)}{z_1 z_T + z_4 z_1 + z_4 z_2 + z_4 z_T}$$

20) 
$$i_b = \frac{E(z_1 z_T + z_1 z_4 + z_2 z_4 + z_4 z_T)}{(z_1 z_3)(z_4 + z_T + z_2) + (z_2 z_4)(z_3 + z_T + z_1) + z_T(z_1 z_2 + z_3 z_4)}$$

Therefore:

21) 
$$i_a = -i_b \left( \frac{z_1 z_3 + z_1 z_4 + z_1 z_T + z_4 z_T}{z_1 z_T + z_1 z_4 + z_2 z_4 + z_4 z_T} \right)$$

22) 
$$i_a = \frac{-E \left( Z_1 Z_3 + Z_1 Z_4 + Z_1 Z_T + Z_4 Z_T \right)}{Z_1 Z_3 \left( Z_2 + Z_4 + Z_T \right) + Z_2 Z_4 \left( Z_1 + Z_3 + Z_T \right) + Z_T \left( Z_1 Z_2 + Z_3 Z_4 \right)}$$

23) 
$$i_D = i_a + i_b$$

$$24) i_{D} = \frac{E (Z_{2}Z_{4} - Z_{1}Z_{3})}{Z_{1}Z_{3} (Z_{2}+Z_{4}+Z_{T}) + Z_{2}Z_{4} (Z_{1}+Z_{3}+Z_{T}) + Z_{T} (Z_{1}Z_{2}+Z_{3}Z_{4})}$$

25) 
$$V_D = \frac{R_D (Z_2 Z_4 - Z_1 Z_3) E}{Z_1 Z_3 (Z_2 + Z_4 + Z_T) + Z_2 Z_4 (Z_1 + Z_3 + Z_T) + Z_T (Z_1 Z_2 + Z_3 Z_4)}$$

Equations 24 and 25 express the diode current and voltage as a function of the general parameters of the circuit.  $R_{t}$  is composed of the decoupling resistors  $R_{c}$  in series with the diode resistance  $R_{D}$ . In the case where the diode is reverse biased,  $R_{\dot{D}}$  can be assumed to be infinite. Equations 24 and 25 then become,

26) 
$$i_D = 0$$

27) 
$$V_D = \frac{(Z_2 Z_4 - Z_1 Z_3)E}{Z_1 Z_3 + Z_2 Z_4 + Z_1 Z_2 + Z_3 Z_4}$$

If the diode is conducting,  $R_{\mathrm{D}}$  approaches zero. Then Equations 28 and 29 can replace Equations 24 and 25.

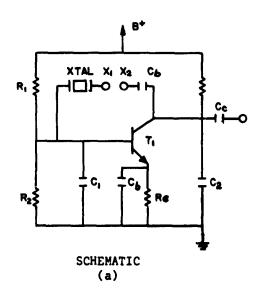
28) 
$$i_D = \frac{E(Z_2Z_4 - Z_1Z_3)}{Z_1Z_3(Z_2+Z_4+2R_c) + Z_2Z_4(Z_1+Z_3+2R_c) + 2R_c(Z_1Z_2+Z_3Z_4)}$$

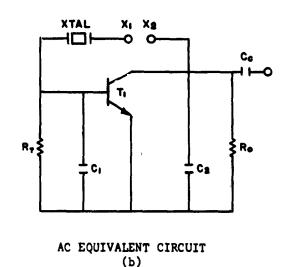
29) 
$$V_{D} = 0$$

From Equation 25 it can be seen that if  $Z_2Z_4 = Z_1Z_3$ , then  $V_D = 0$ . This relationship is true for any magnitude of  $Z_1$ ,  $Z_2$ ,  $Z_3$  and  $Z_4$ . To obtain zero bias with the bridge it is not necessary to approach 0 or infinity with any of the compensating resistances.

In Equations 24 and 25,  $R_t$  is composed partially of the diode resistance,  $R_D$ . Therefore, the resistance,  $R_t$ , is a function of  $V_0$  due to the diodes characteristics. If an equation can be written relating  $Z_D$  to  $i_D$  or  $V_D$  and if  $R_D$  can be expressed in terms of  $i_D$  or  $V_D$ , then the complete relationship between  $Z_D$  and  $i_D$  can be written in terms of the DC circuit parameters. This can be done to a very good approximation, but is not necessary for all practical purposes.

The oscillator configuration that is used for conducting tests and for compensation has been examined to optimize the parameter values. Figure 3.1.8(a) is the basic oscillator schematic that is being used.  $R_1$ ,  $R_2$ ,  $R_e$  and  $R_c$  are the transistor bias resistors.  $C_1$  and  $C_2$  are part of the oscillator network and form part of the crystal load impedance. Terminals  $X_1$  and  $X_2$  are the points of connection of the varicap or compensation network.





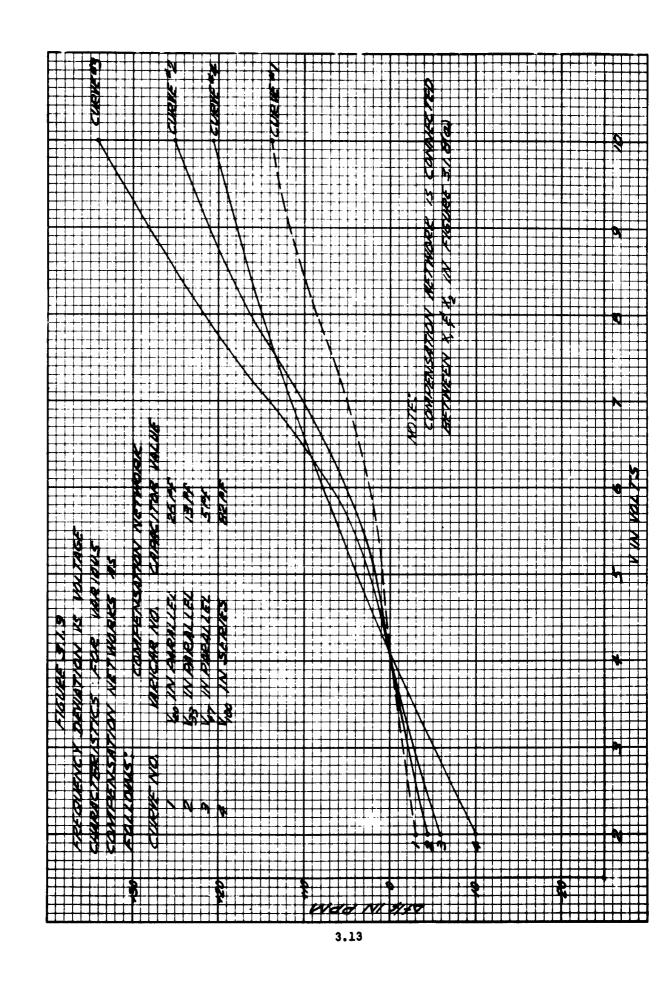
, BASIC OSCILLATOR CONFIGURATION Figure 3.1.8

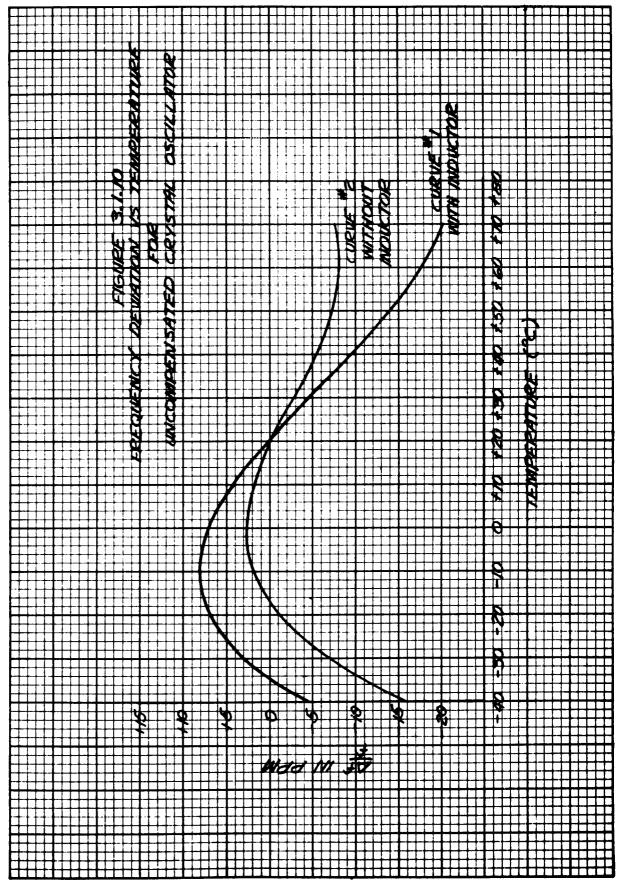
The ratio of  $C_1$  to  $C_2$  and the magnitude of  $C_1$  and  $C_2$  affects the range of the compensation circuit and the stability of the oscillator. By simply examining the equivalent a-c circuit for the oscillator shown in Figure 3.1.8(b), it can be seen that if  $C_1$  and  $C_2$  are increased, the effect of  $C_x$  will become greater. Stray capacitance will be damped out by the increase in  $C_1$  and  $C_2$ , which results in increased circuit stability.

The effect of using various types of varicaps and paralleling varicaps with capacitors to obtain different characteristics was investigated. The frequency of the oscillator was set to the crystal frequency corresponding to a load capacity of 32 pfd when four volts was applied across the varicap.

Curves #1 through #4 in Figure 3.1.9 indicate the effect on the pullability of the varicaps as a function of varicap type and parallel capacitance combination.

Oscillators used in the work performed during the first quarter in general had inductors placed in series with the crystal to operate the crystal at series resonance. Curves obtained for the frequency versus tempera-

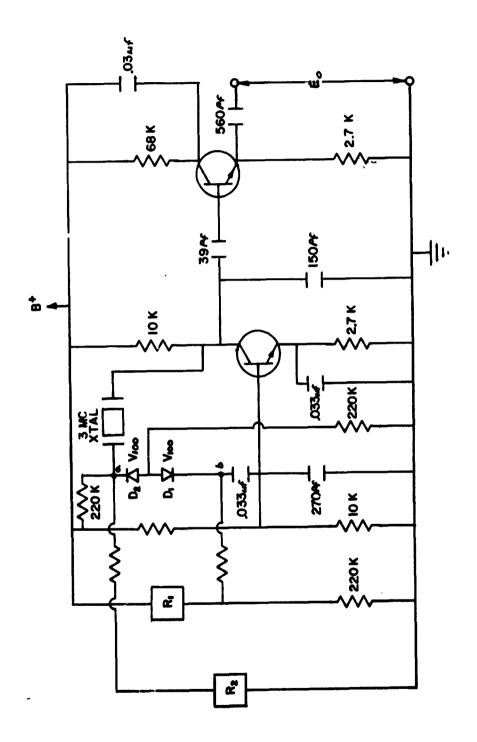




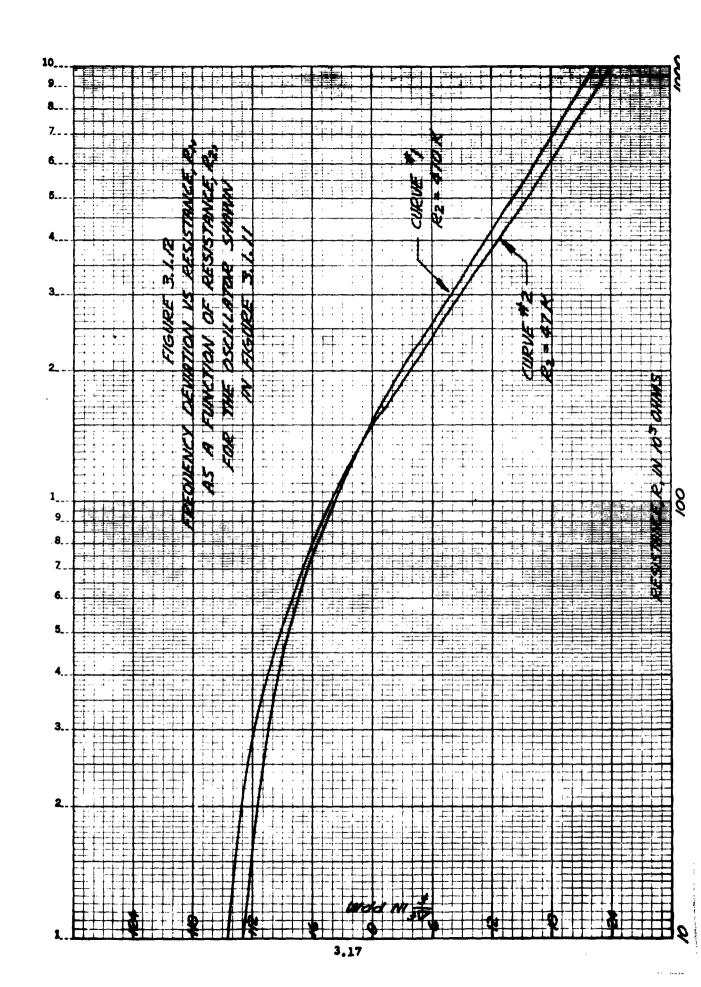
ture characteristics of a number of oscillators were not consistant with the crystal curves. To determine what caused this, a number of tests were performed, one of which was checking the frequency temperature characteristics of oscillator with and without an inductor. Figure 3.1.10 indicates the effect of one inductor. This particular inductor had a very large temperature coefficient which was not typical, but indicated that the error in the frequency-temperature characteristics was probably due to the temperature coefficient of the series inductors.

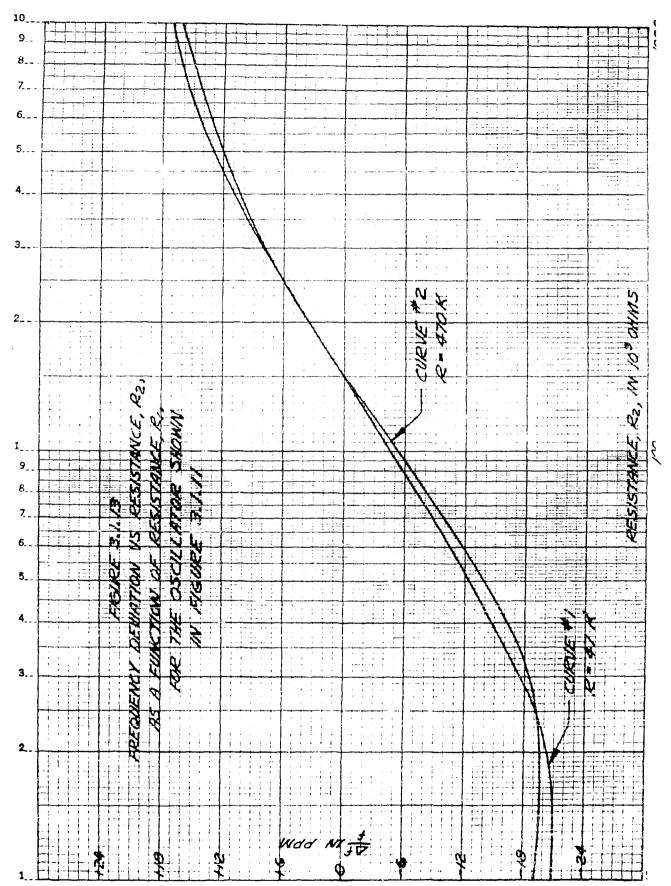
A number of test circuits were built to test the characteristics of the two varicap compensation methods. The first test was directed at finding whether or not changing one of the compensating resistances affected the characteristics of the  $\Delta f/f$  versus resistance of the other compensating networks.

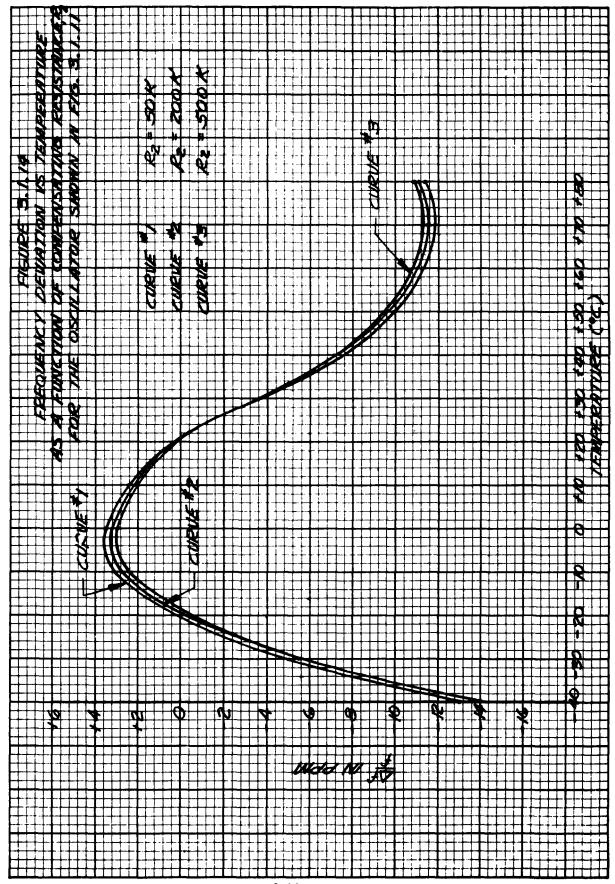
The oscillator used for the tests is shown in Figure 3.1.11.  $R_1$  is the control resistance for varicap,  $D_1$  and  $D_2$  are the control resistance for varicap  $D_2$ . Figure 3.1.12 shows the effect of changing  $R_2$  on the  $\Delta f/f$  versus  $R_1$  characteristics of the compensation circuit. The two curves indicate that the effect is negligible, because the frequency was only recorded to an accuracy of  $\pm$  3 parts in  $10^7$  and the maximum deviation shown in Figure 3.1.12 is 1 PPM. Figure 3.1.13 shows the effect of changing  $R_1$  on the  $\Delta f/f$  versus  $R_2$  characteristics of the oscillator. The maximum deviation is approximately 1.5 PPM. Under normal conditions  $R_1$  will only vary slightly when  $R_1$  is being used for compensation. The variation of  $R_2$  in Figure 3.1.13 and  $R_1$  in Figure 3.1.12 is many times what will normally be expected; therefore, the error in the compensation curve will be considerably less than the total deviation shown in Figure 3.1.12 and 3.1.13.



TWO VARICAP COMPENSATED OSCILLATOR FIGURE 3.1.11

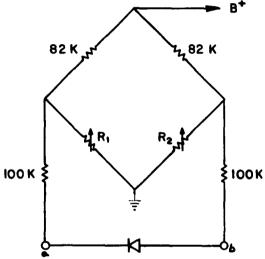






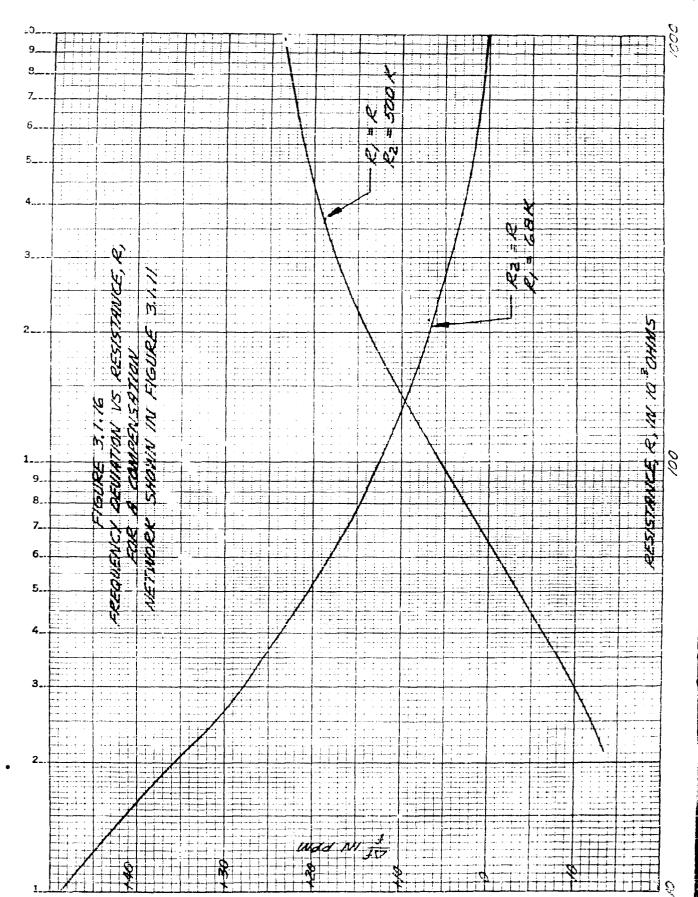
3.19

The temperature effect of the varicap with various biasing resistances is another area where a problem may be present. Figure 3.1.14 is a curve of  $\Delta f/f$  versus temperature for the oscillator for various values of  $R_2$ . The effect of the compensation network can be assumed negligible, because the errors observed were within the accuracy limitations of the frequency measurements. A large number of varicaps were tried in this same circuit and the results were all similar to those that are shown in Figures 3.1.12, 3.1.13, and 3.1.14.



TYPICAL BRIDGE CIRCUIT USED FOR COMPENSATION STUDIES
Figure 3.1.15

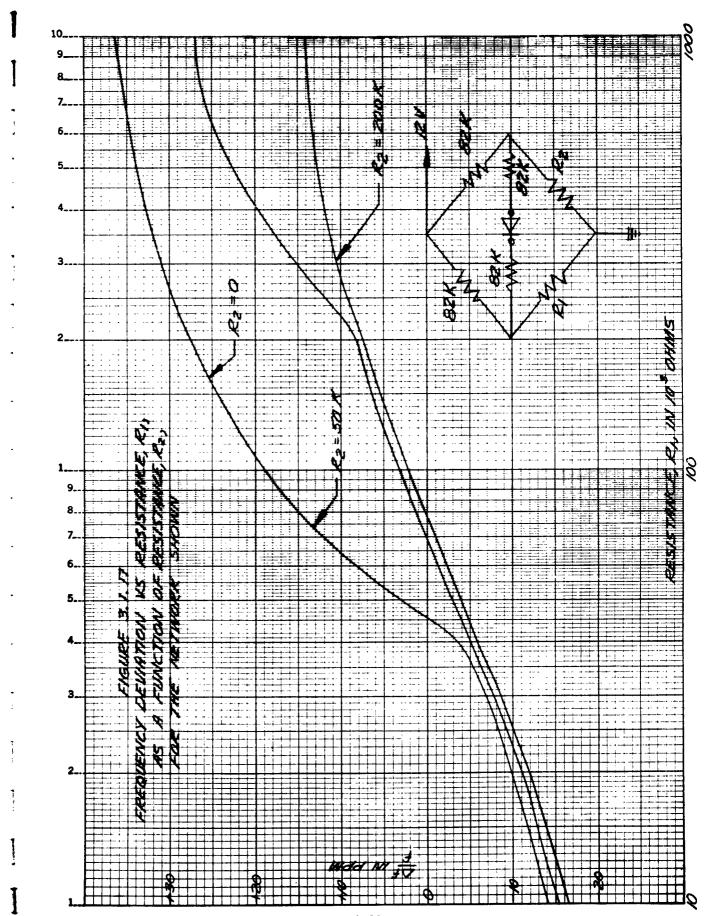
The test circuit shown in Figure 3.1.15 is the bridge circuit which was connected to points (a) and (b) in Figure 3.1.11 to obtain data on a varicap in a bridge circuit. Figure 3.1.16 shows the frequency characteristics of the oscillator as a function of the bridge resistances  $R_1$  and  $R_2$ . In this case  $R_2$  was varied while  $R_1$  was set equal to 68 K and  $R_1$  varied while  $R_2$  was set equal to 500 K. The purpose for this can be seen if the curves are related to the changes required for  $R_1$  and  $R_2$  to compensate an AT cut crystal.  $R_2$  will control the compensation network for temperatures above the lower

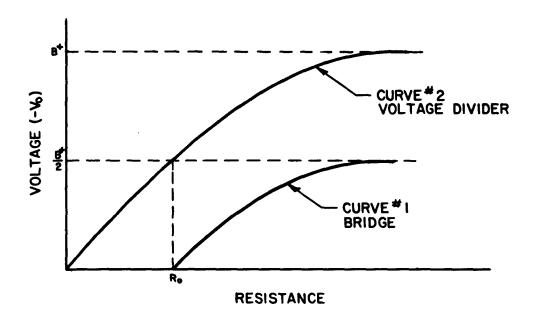


turning point of the crystals characteristic frequency-temperature curve and  $R_1$  will control the compensation network below the turning point. Thus,  $R_1$  and  $R_2$  will both be small at the highest temperature, then  $R_2$  will increase and  $R_1$  will remain constant as the temperature is decreased to the lower turning point, where  $R_1$  will increase and  $R_2$  held constant as the temperature is further reduced to a minimum value.

Figure 3.1.17 indicates the frequency versus resistance,  $R_1$ , as a function of  $R_2$  characteristics of the oscillator using the network shown. As can be seen from the curves, the magnitude of  $R_2$  has a very pronounced effect on the  $\Delta f/f$  versus  $R_1$  characteristics of the compensation network. When  $R_1$  is small,  $R_2$  has little effect on the slope of the  $\Delta f/f$  versus  $R_1$  curve, but as  $R_1$  is increased,  $R_2$  has a considerable effect on the characteristics. The reason for the effect of  $R_2$  on the  $\Delta f/f$  versus  $R_1$  characteristics is due to the effect of forward biasing the varicap. When the varicap is reverse biased and slightly forward biased, the characteristics of the compensation network is uniform, but as the diode becomes more forward biased the diode's characteristics change appreciably as can be deduced from the curves in Figure 3.1.17.

Figure 3.1.18 is a graph that compares the voltage output versus resistance of a bridge circuit and a voltage divider. If all resistance values are held constant, then the bridge circuit voltage output goes from 0 to a maximum of B+/2 and the voltage divider output goes from 0 to a maximum of B+. But, the resistance in the voltage divider must vary from 0 to infinity, where the resistance in the bridge must only vary from some arbitrary value, R, to infinity.





COMPARISON OF BRIDGE AND VOLTAGE DIVIDER VOLTAGE OUTPUTS AS A FUNCTION OF RESISTANCE Figure 3.1.18

#### 3.2 Transistor Method

The theory of the transistor method of compensation was presented in the First Quarterly Report and will not be discussed at length in this report.

In the previous Quarterly Report is was shown that compensation could be achieved by using the collector to base junction capacitance of the transistor.

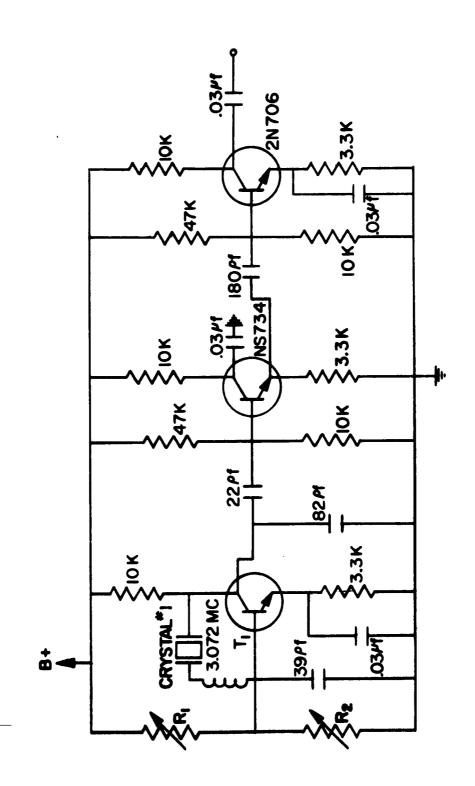
The remaining questions to be answered about this method of compensation are

(1) the degree of compensation that can be obtained using the transistor method, (2) the reproducibility of a compensation curve provided by using various transistors in a fixed oscillator and compensation network configuration, (3) the effect of temperature on the pullability curves, and (4) difficulty of synthesizing a required compensation network.

A series of tests were performed on a number of transistors in an effort to answer some of the above questions. The oscillator shown in Figure 3.2.1 was used for these tests, where all of the components remained the same except the transistor. A group of five transistors were tested in this circuit. The transistors used and their corresponding DC betas are listed below.

Table #1

|            | Туре     | Manufacturer        | DC Beta |
|------------|----------|---------------------|---------|
| 1.         | 2N697    | Texas Instruments   | 53      |
| 2.         | 2N697    | Texas Instruments   | 62      |
| 3.         | 2N697    | Fairchild           | 64      |
| <b>4</b> ° | RT(5230) | Rheem Semiconductor | 92      |
| 5.         | RT(5230) | Rheem Semiconductor | 91      |

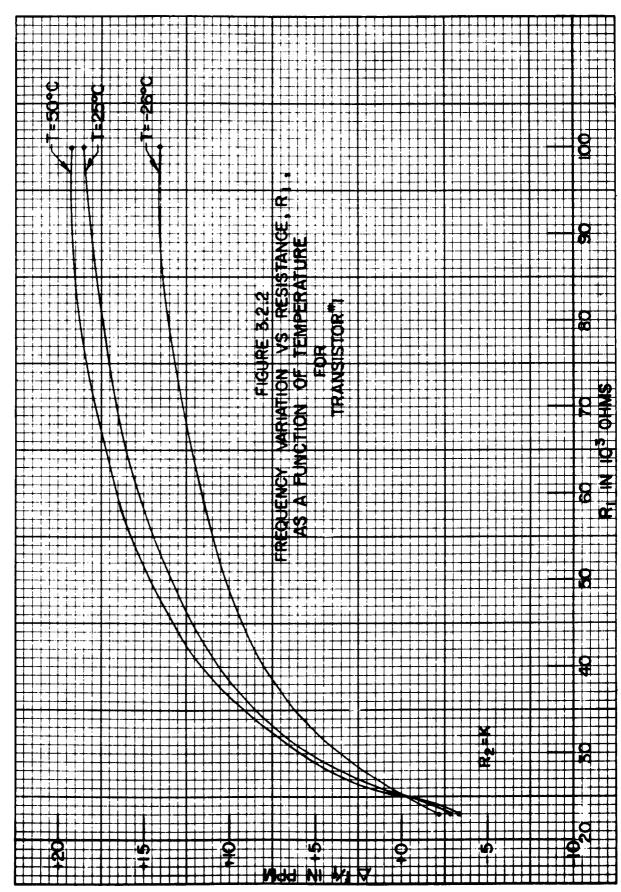


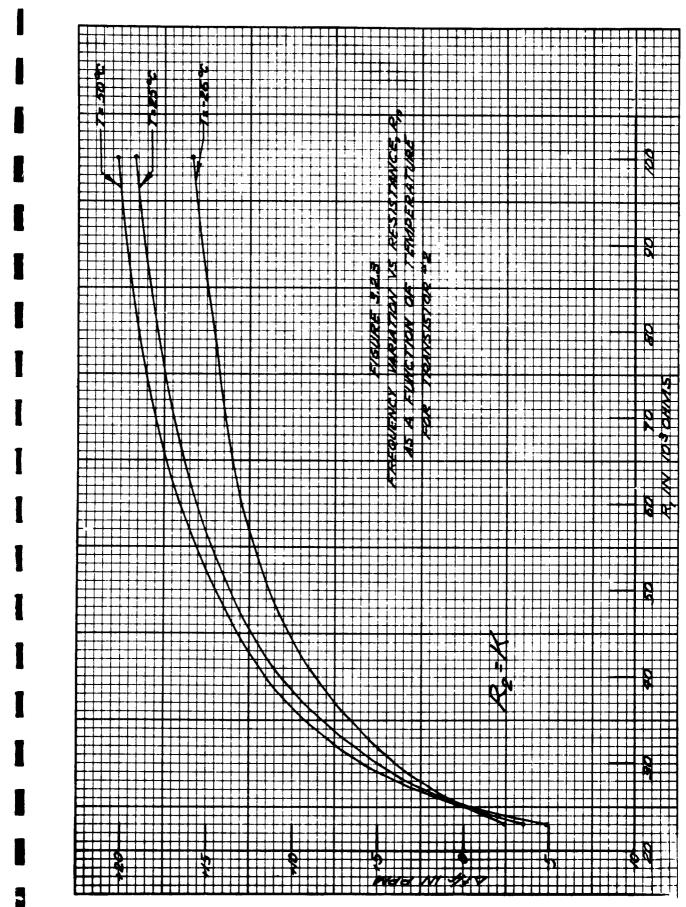
SCHEMATIC OF OSCILLATOR USED FOR TRANSISTOR METHOD

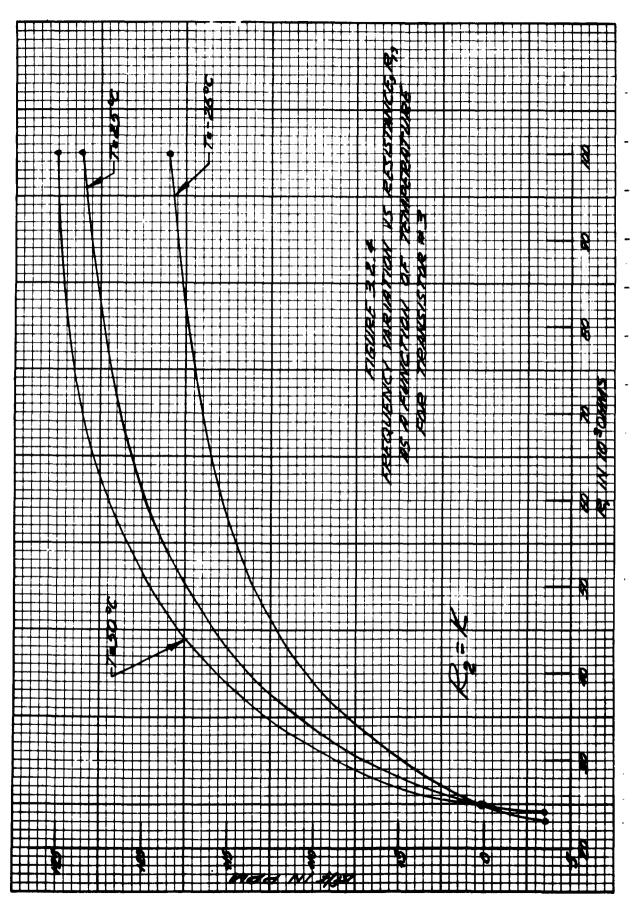
 $R_1$  and  $R_2$  in Figure 3.2.1 are decade boxes in the test circuit and would be replaced by thermistor-resistor networks when the oscillator was to be compensated over temperature. If NTC thermistors are used for compensation, then  $R_1$  and  $R_2$  will be at their maximum values at the lowest ambient temperature and they will be at their minimum values at the highest ambient temperature. This dictates what part of the crystal  $\Delta f/f$  versus temperature curve that  $R_1$  and  $R_2$  will control. In general, as  $R_1$  decreases, the frequency decreases and as  $R_2$  decreases the frequency increases. Therefore, if an AT cut crystal is to be compensated,  $R_1$  must be used for temperature compensation from the lowest temperature to the lower turning point and  $R_2$  must be used from the lower turning point to the upper turning point.

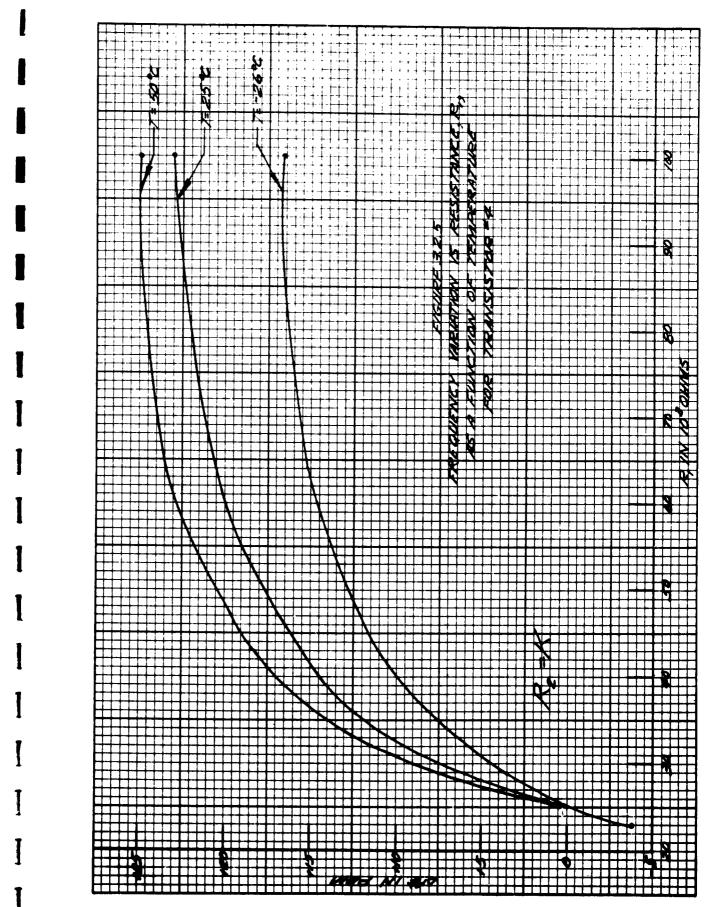
With this fact in mind, the pullability curves,  $\Delta f/f$  versus R, were obtained by setting both  $R_1$  and  $R_2$  at their maximum values or the largest value at which they should be operated.  $R_1$  was then decreased to its lowest value and the  $\Delta f/f$  versus R data was recorded. Then  $R_1$  was left at its minimum value, while the  $\Delta f/f$  versus  $R_2$  data was recorded as  $R_2$  was varied from its maximum to its minimum value. This in effect simulates the manner in which  $R_1$  and  $R_2$  would have to vary as the temperature changes from its lowest value to its maximum value. Figure 3.2.2 through 3.2.6 are the pullability curves of  $\Delta f/f$  versus  $R_1$  for the five transistors tested as a function of temperature. Figures 3.2.7 through 3.2.11 are the pullability curves of  $\Delta f/f$  versus  $R_2$  for the five transistors tested as a function of temperature.

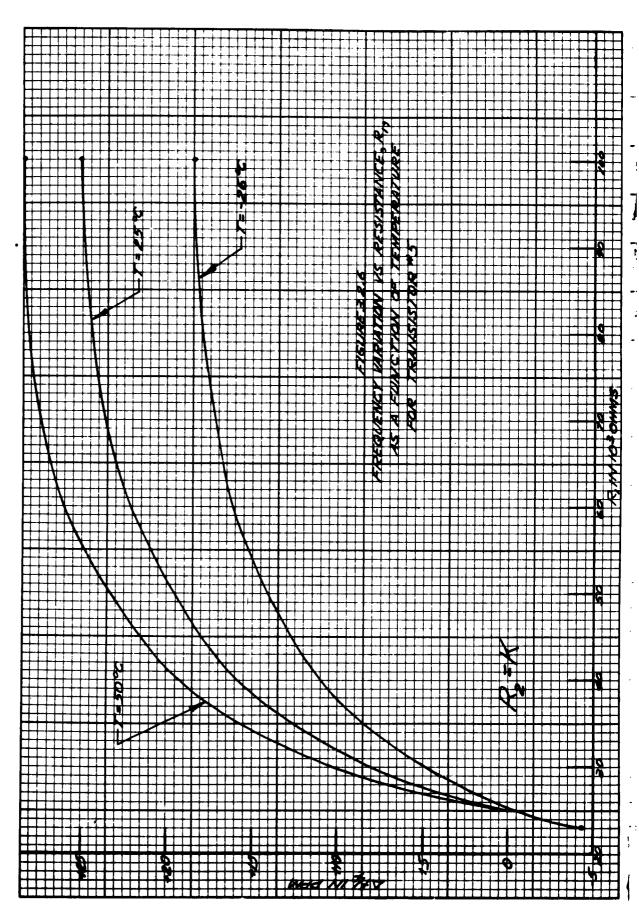
Figure 3.2.12 and 3.2.13 compare the pullability at room temperature of the five transistors that were tested. As can be seen, Transistor #5 has the greatest change in frequency and Transistor #1 has the least change for a given change in resistance. The characteristics of the five transistors tested are all similar. The only difference in the curves is the slope or the

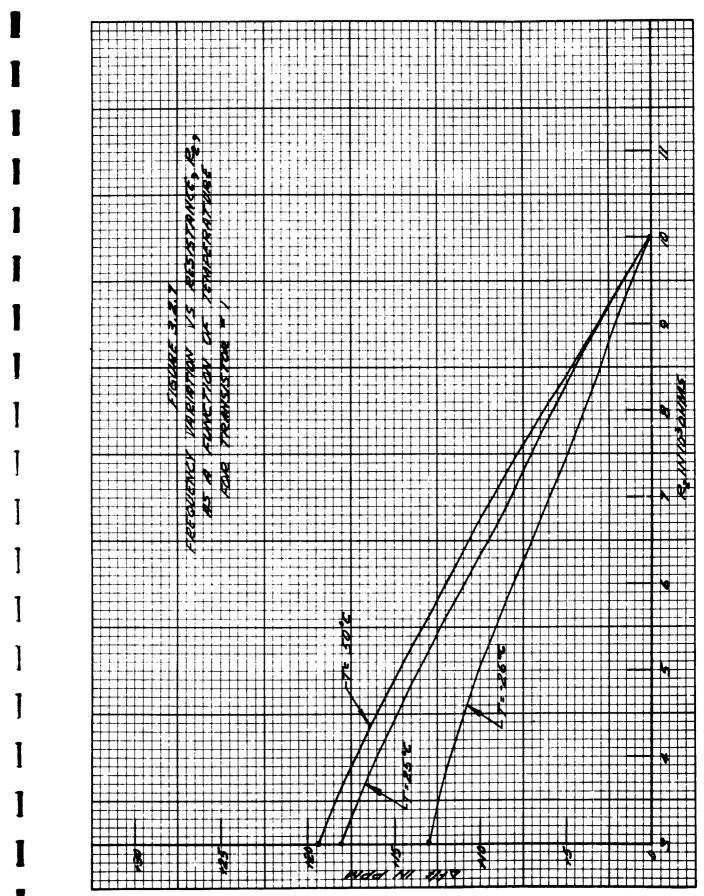


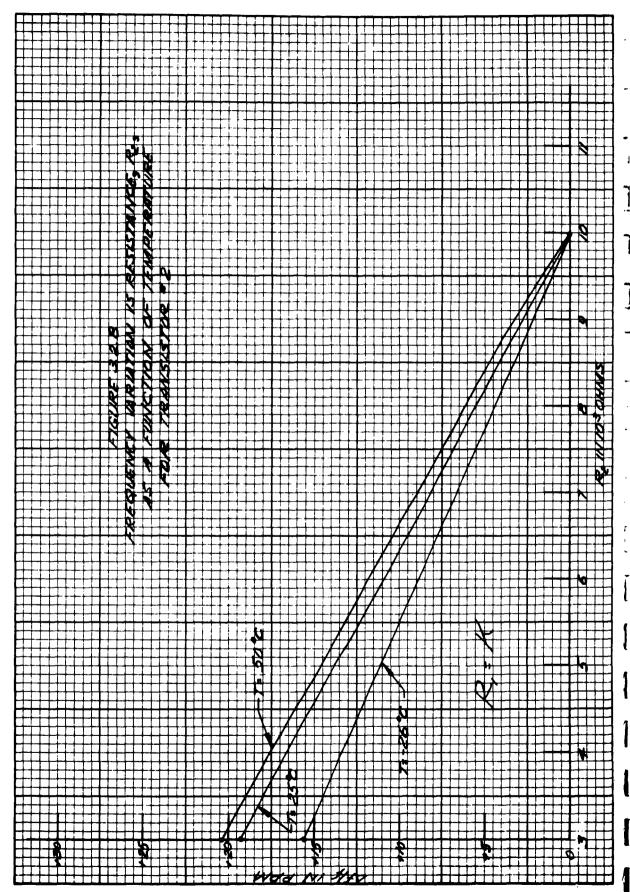


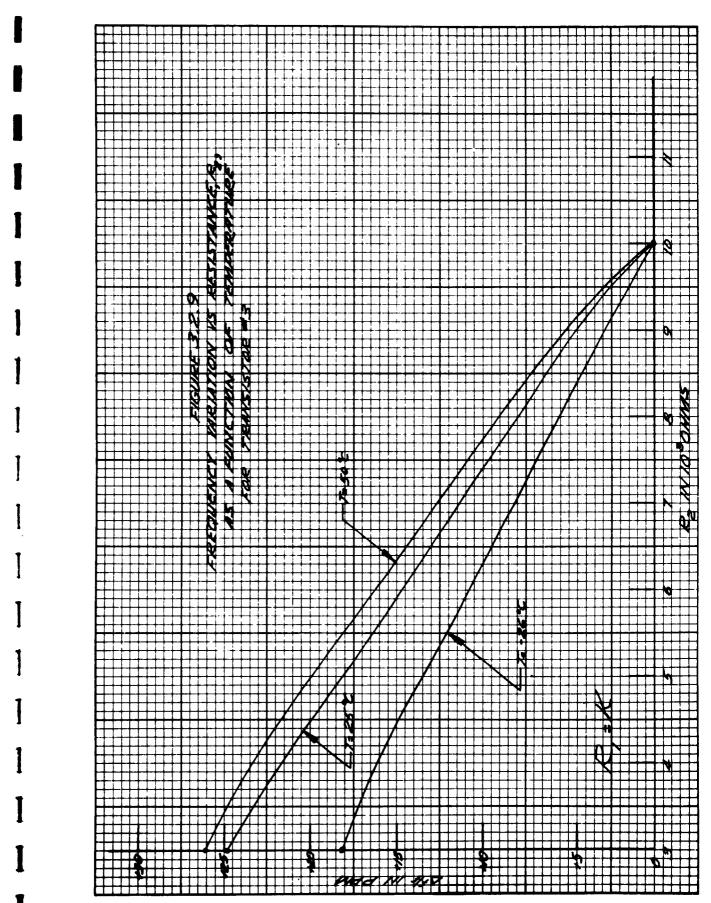


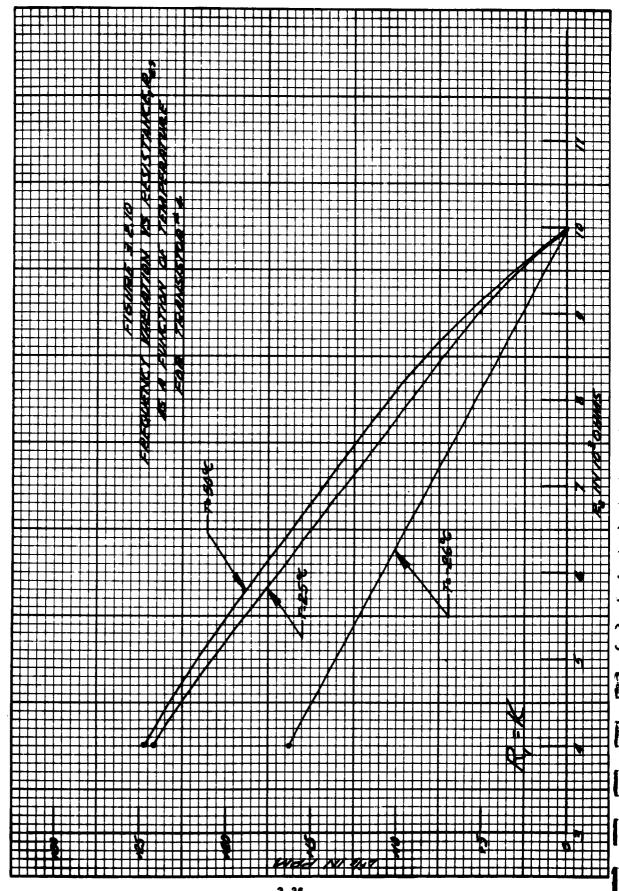




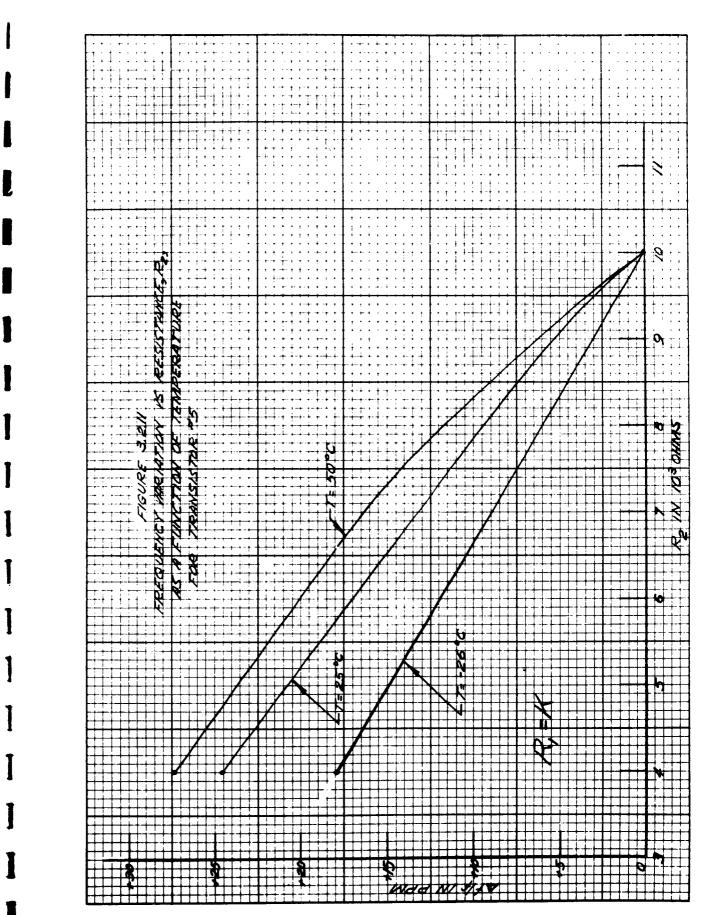


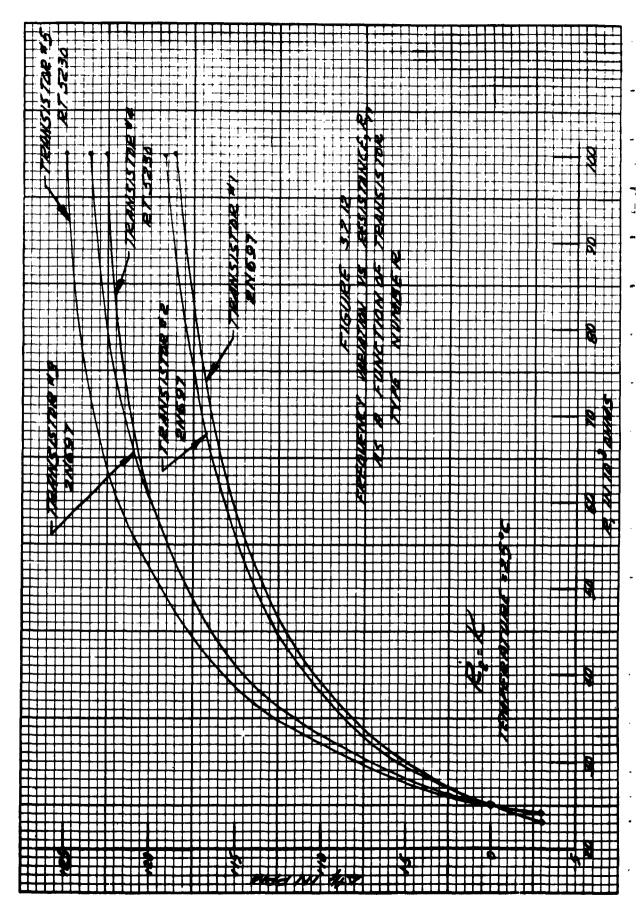


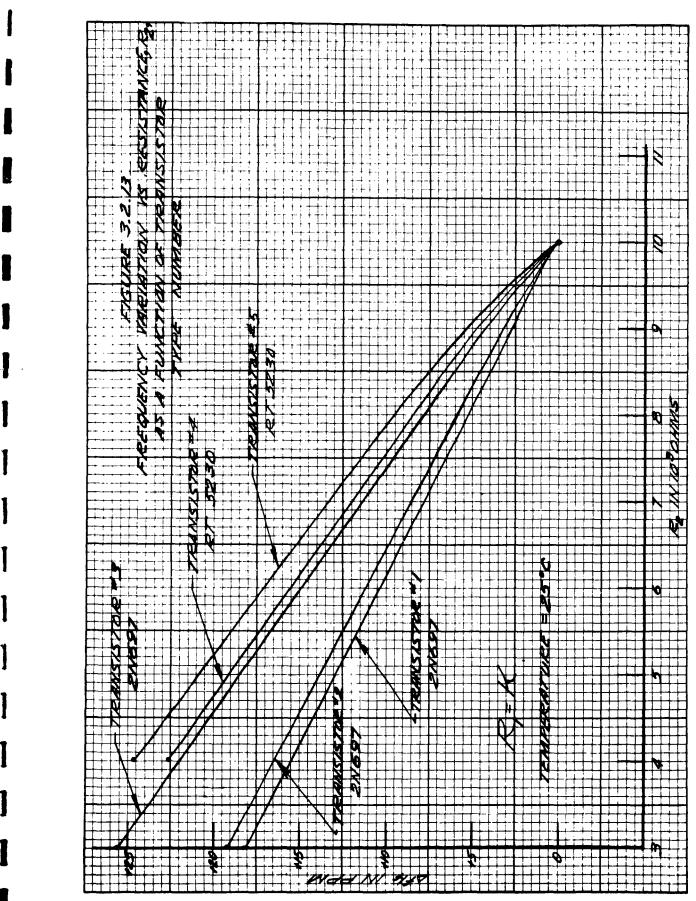




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incremental change in frequency for a given change in resistance. The temperature effects on the pullability of the various transistors is also only a matter of a difference in slope of the curves. In the previous Quarterly Report, it was shown that the beta of the transistor has an effect on the pullability of the transistor.

Table #2 indicates the effect of changing the oscillator bias voltage on the frequency of oscillation. The  $\Delta f/f$  versus voltage characteristics are recorded as a function of temperature with a constant bias.

Table #2

| Transistor No. | Frequency Deviation (Δf/f) per Volt (Bias Voltage) |  |   |
|----------------|--|--|---|
|                | $T = -26^{\circ}C$ $R_1 = 100K$ $R_2 = 10K$        | T = 25°C<br>R <sub>1</sub> = 25K<br>R <sub>2</sub> = 10K | T = 50°C<br>R <sub>1</sub> = 25K<br>R <sub>2</sub> = 4K |
| 1              | +0.51  | +0.25  | +0.49   |
| 2              | +0.51  | +0.25  | +0.48   |
| 3              | +0.60  | +0.02  | +0.42   |
| 4              | +0.40  | -0.02  | +0.31   |
| 5              | +0.44  | -0.11  | +0.40   |

The transistor method has some advantages over the other methods of compensation. One is the simplicity of the circuit. A minimum number of components are used in the compensated oscillator. Another is the relative simplicity of the compensating thermistor-resistor networks,  $R_1$  and  $R_2$ . There are limits on the magnitude of  $R_1$  and  $R_2$  placed by the transistor because there is a minimum gain that can be tolerated and operation must remain within those limits. The curve of  $R_1$  versus temperature and  $R_2$  versus temperature is easily approximated by a simple combination circuit with only minor variations from one transistor to the next if transistors were selected by checking the

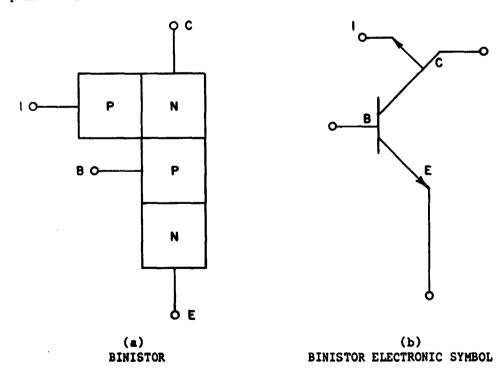
C<sub>cb</sub> versus V<sub>cb</sub> characteristics of each transistor.

There are also a number of disadvantages to the transistor method. The main one is that to obtain very close compensation, for example 1 PPM or better, more than one temperature run will be necessary in most cases. Also the value of thermistors may need to be changed for each transistor which precludes the use of a fixed standard compensation network. Another major problem that is encountered when using the transistor method for compensation is the voltage coefficient that is exhibited. A voltage variation of less than 1 volt is required to maintain a change less than 0.5 PPM. Even if the oscillator is temperature compensated, the best stability that could be obtained will be dictated by the voltage coefficient and voltage regulation of the oscillator.

Using the isolation stage method of compensation in conjunction with the transistor method will increase the temperature stability, but the voltage effect will remain approximately the same. The transistor method appears to be a feasible method of compensation where stabilities with temperature of 1 PPM or larger are desired, but does not seem to be practical at this time for stabilities better than 1 PPM over the temperature range of -40°C to +70°C.

## 3.3 Binistor Compensation Method

The binistor method of compensation depends on the capacitance change of a semiconductor junction, as do the other methods of compensation. The primary difference between the binistor method and the other methods of compensation is that part of the junction to be used as a voltage variable capacitor is internal to the transistor and part is external. Figure 3.3.1(a) and 3.3.1(b) illustrate the manner in which a binistor is physically constructed and the electronic symbol for the binistor. The binistor is a PNPN device with leads attached to all four distinct areas. The binistor can be considered as a NPN transistor with a P-type semiconductor, call the injector, attached to the collector. The injector-collector junction is the junction to be used for compensation.



BINISTOR CONFIGURATION Figure 3.3.1

The oscillator configuration can be the same as shown for the other type of compensation with the crystal connected to the collector through the injector terminal. By applying the proper biasing potential across the injector-collector junction, the capacitance of the junction will vary in such a manner that the oscillator will be compensated over temperature.

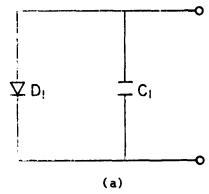
One problem associated with using the injector to collector junction as a voltage variable capacitance is that it cannot be DC isolated from the active network. The DC bias supply that provides  $V_{\rm ic}$  has a path through the transistor as well as through the injector to collector junction.

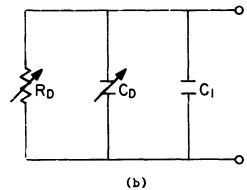
Another problem is that binistors with large values of C<sub>ic</sub> are not readily available. A test sample of five binistors, 3N57, were obtained and tested. All five had such low junction capacitances that they were not adequate for compensation purposes.

Further work on the binistor method of compensation is being postponed until it can be determined if binistors with larger values of  $C_{ic}$  are available.

## 3,4 Capacitor-Diode Compensation Method

During the last quarter the capacitor-diode method has been investigated more thoroughly. The analysis presented in the First Quarterly Report is not adequate to explain the entire phenomena of the capacitance change of the forward-biased diode in parallel with the fixed capacitor. In the previous analysis of the circuit in Figure 3.4.1(a), the effect of the diode capacitance was not considered. Figure 3.4.1(b) is a more accurate electrical equivalent circuit.





DIODE COMPENSATION NETWORKS
(a) WITHOUT AND (b) WITH DIODE CAPACITANCE SHOWN
Figure 3.4.1

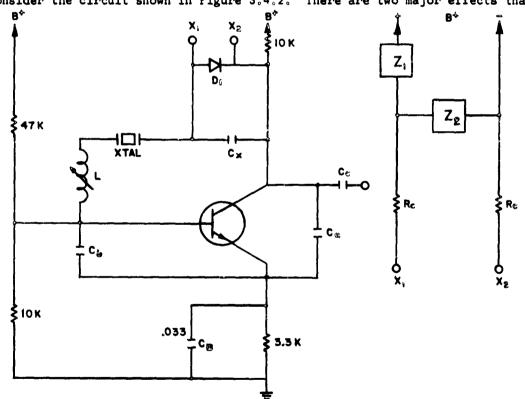
Figure 3.4.1(b) shows  $C_1$  as the external capacitor,  $C_D$  as the effective capacitance of the diode and  $R_D$  as the effective parallel a-c resistance of the diode. Both  $R_D$  and  $C_D$  will vary as the bias voltage is increased in the positive direction.  $R_D$  will decrease towards zero,  $C_D$  will increase towards infinity, and the sum  $C_D + C_1$  will also increase towards infinity.

The bridge method of generating a control voltage discussed in the section on varicap compensation is also applicable to the capacitor-diode method. The fact that the bridge circuit allows operation through the zero bias point makes the capacitor-diode method more flexible. The analysis of the operation of the bridge in the forward direction proceeds along the same lines as the

analysis for the varicap bridge circuit. Equations 24 and 25 in Section 3.1 for  $i_D$  and  $V_D$  are applicable when the diode is biased in the forward direction, but the assumption that  $Z_T$  = infinity made in Equations 26 and 27 cannot be made for the forward-biased diode.  $Z_T$  will vary from a very large value to a value approaching  $2R_C$  and  $R_D$  will go from a very large value towards zero. The voltage across the diode biased in the forward direction can vary from zero to approximately one volt depending upon  $R_C$  and the diode.

A method of obtaining an almost zero voltage coefficient has been found.

Consider the circuit shown in Figure 3.4.2. There are two major effects that



CAPACITOR-DIODE COMPENSATION CIRCUIT Figure 3.4.2

change the frequency of the oscillator as the supply voltage is varied. One is the change in bias point of the compensating diode. As B+ is increased,

the voltage across the diode increases, the capacitance exhibited by the diode increases and the frequency of oscillation decreases. Also, as B+ is increased the change in collector to base voltage is given by Equation 1 below, (Section 4.3, Equation 19 from the First Quarterly Report).

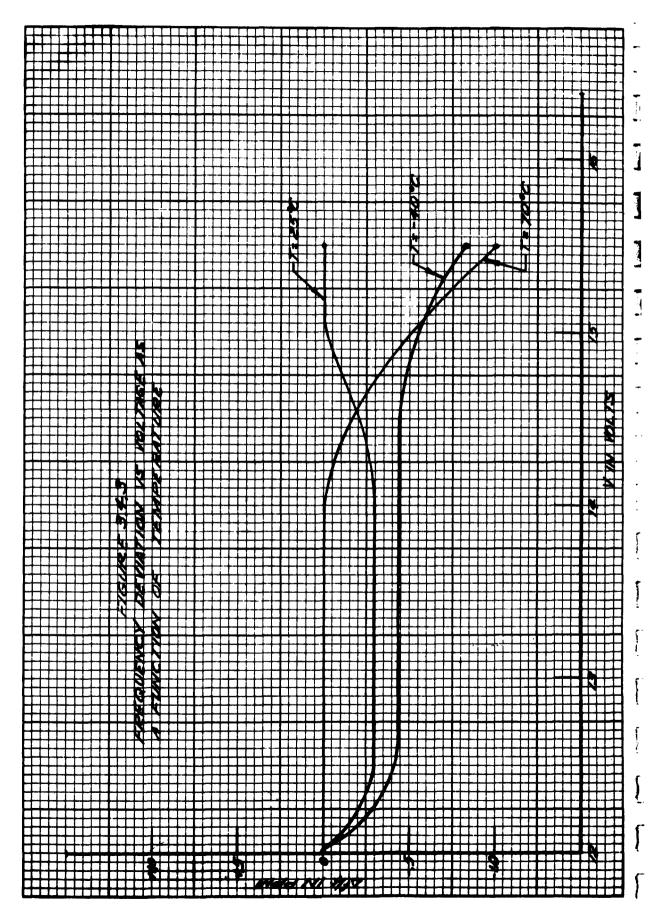
1) 
$$\frac{dV_{cb}}{dE} \stackrel{?}{=} \frac{R_1R_e - R_cR_2}{R_1R_e + R_2R_e + R_1R_2}$$

This equation indicates that the collector to base voltage can be increased or decreased with an increase in B+ or E depending on the values of  $R_1$ ,  $R_2$ ,  $R_e$  and  $R_c$ . The change in  $V_{cb}$  with a variation in supply voltage can be made zero if the following is true.

2) 
$$R_1 R_e = R_c R_2$$

If the V<sub>cb</sub> is made to increase with an increase in B+, then the oscillator to base capacitance will decrease, increasing the frequency of the oscillator. The total change in frequency due to a change in B+ can be made very close to zero over a limited voltage range if the change in frequency due to the change in capacitance of the collector to base junction is adjusted to be equal to the change caused by the compensation network.

The curves in Figure 3.4.3 are the frequency versus supply voltage characteristics of an oscillator whose bias resistors have been adjusted to yield an almost zero voltage coefficient over a limited voltage range. The effect of temperature is shown in Figure 3.4.3. Over the temperature range of -40°C to +70°C a zero voltage coefficient is maintained for a supply voltage



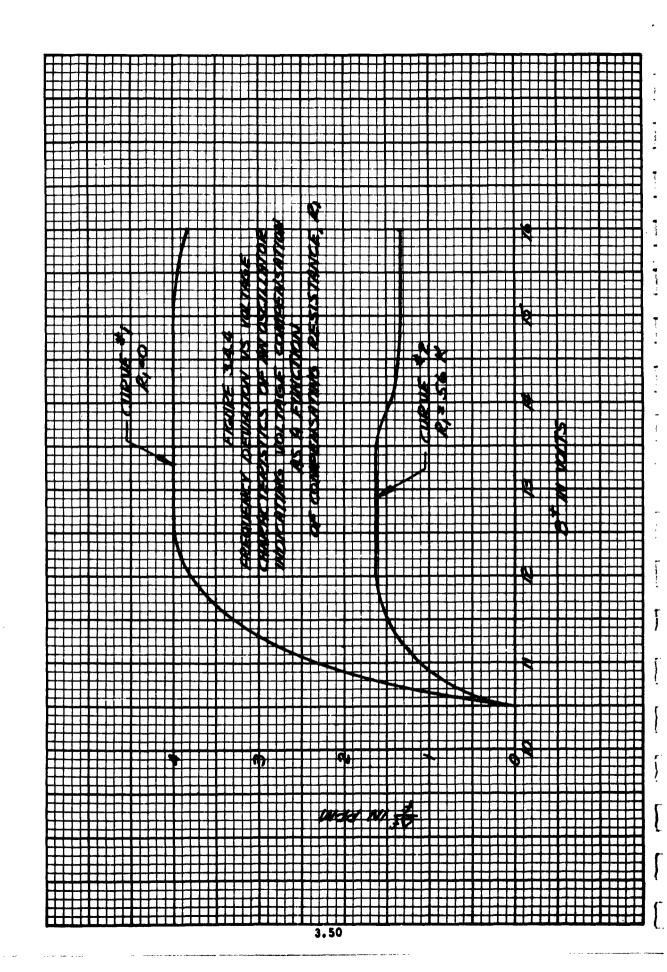
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of from about 12.5 volts to 14 volts. Figure 3.4.4 shows the effect of varying the compensation network on the frequency versus supply voltage characteristics.

By establishing the proper bias point, a voltage coefficient of close to zero may be established. Consequently, this will reduce the amount of voltage regulation that is required for a compensated oscillator circuit. This method of obtaining a zero voltage coefficient may be used with the varicap method, but may not be used for the transistor method of compensation.

The compensation of an oscillator with specific circuits, components, crystals and compensation networks means that each oscillator has to be compensated individually. One way of decreasing the amount of time for compensation of a number of oscillators would be to obtain components with identical characteristics. If very close tolerances were placed on each component to be used in a compensated oscillator, interchanging components should have very little effect on the frequency items.

Obtaining components that have identical characteristics from unit to unit is difficult. It is nearly impossible to make a large number of crystals with identical frequency-temperature characteristics and  ${\rm C_o/C_l}$  ratios. The reverse and forward biased characteristics of diodes will vary slightly from one unit to another even if they are the same type. Thermistor beta and  ${\rm R_o}$  will vary from unit to unit by certain amounts. All of these variations make it almost impossible to build a standard circuit for compensation with no provision for adjustment. No matter how close the tolerances are held on each component the variations will still be present and will effect the compensation afforded by a given design.



Means other than giving extremely small tolerances on components must be devised before a standard circuit will be practical. In order to devise means of standardizing oscillator and compensation networks, a study has been initiated. The parameters that affect compensation and the parameters that can be varied to adjust for differences in components are being investigated.

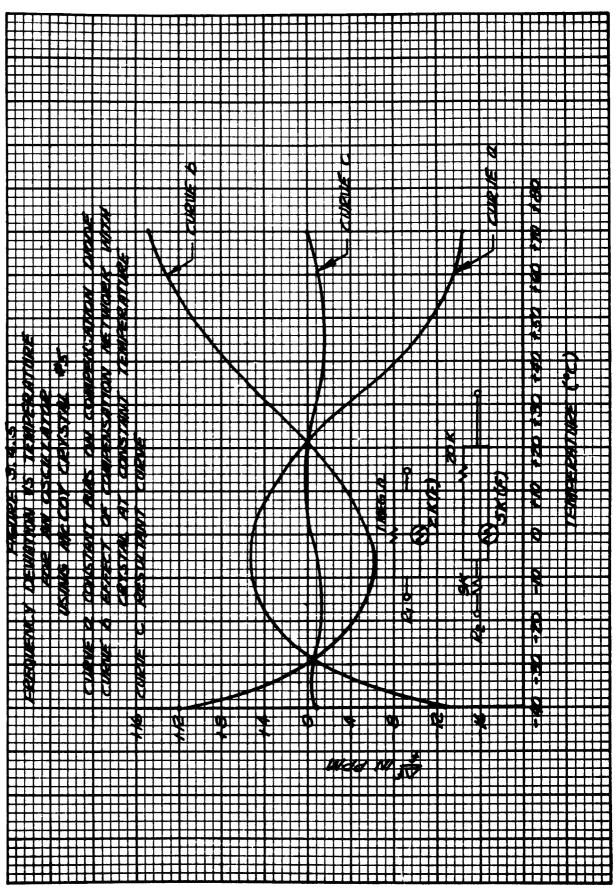
The crystal is the major element in any compensated oscillator. The frequency-temperature curves of the crystal dictates the compensation that is needed. The  $C_{\rm O}/C_{\rm I}$  ratio of the crystal determines the capacitance change with temperature required to compensate the frequency temperature characteristics of the crystal. Once a crystal has been obtained and is to compensated, there is little that can be done to change its characteristics. Therefore, adjustments for the difference between crystal characteristics must be made elsewhere in the oscillator. The capacitance versus voltage curve for a diode determines the voltage or resistance versus temperature characteristics that are required for compensation. Since the diode characteristics cannot be altered, the thermistor-resistor network is the only part of the oscillator that is left to provide adjustment. If a standard thermistor-resistor network is to be used, then either the supply voltage must be used for adjustment or existing or additional networks must be used to adjust for variations in component parameters.

When there is a wide variation in the crystal's parameters, it will be necessary to alter the thermistors in the thermistor-resistor network and possibly to change the diode. When the crystal's parameters do not vary widely, it may not be necessary to alter thermistors, but the resistor values may have to be changed. One of the possibilities of having a standardized compensation circuit is to provide variable resistors in the thermistor-resistor network.

The other possibility mentioned previously of having an additional network in the compensation circuit to correct for changes in component parameters is also feasible. The capacitor diode method has a built-in correction network. The decoupling resistors,  $R_{\rm c}$  in Figure 3.4.2(b), directly affect the slope of the  $\Delta f/f$  versus R curves for the compensation networks. By varying the value of  $R_{\rm c}$ , the  $\Delta f/f$  versus R characteristics of the compensation network can be altered over a wide range because this, in effect, changes the magnitude of the current through the diode and, consequently, the effect of the resistance. Also the capacitor across the diode affects the  $\Delta f/f$  versus R characteristics of the diode. By using both of these means of adjusting the pullability of the compensation network and variable resistors in the compensation network. Adjustment for a wide range of component parameters should be obtainable.

One other possibility that exists for correcting for component variations is to use a TC capacitor. Using a TC capacitor across the crystal can effectively change the apparent angle of cut of the crystal. Thus by selecting values of TC capacitors, a group of crystals can be made to have almost identical temperature characteristics. Also if a component variation causes an error in compensation of a constant slope, a TC capacitor may provide a means of correcting the error in slope. The methods discussed correcting for errors due to component variations is not restricted to the capacitor diode method but are general in nature.

A number of tests were conducted on various phases of the capacitor diode compensation techniques. Figure 3.4.5 is a plot of the  $\Delta f/f$  versus temperature characteristics of a temperature compensated three megacycle oscillator. The schematic for the oscillator circuit used to obtain the curves in Figure 3.4.5 is shown in Figure 3.4.6. Previously,  $R_1$  and  $R_2$  have



been used for compensation purposes. In this instance, instead of using  $R_1$ for compensation at the low temperature range, another compensation element,

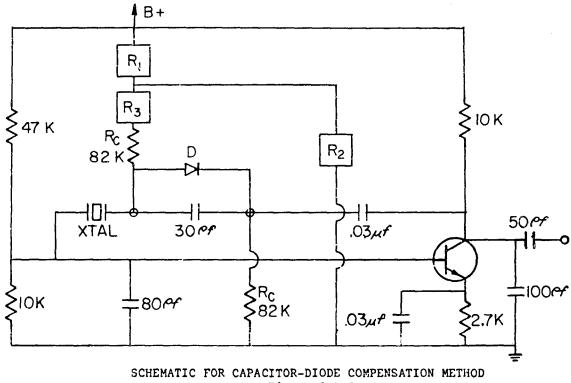
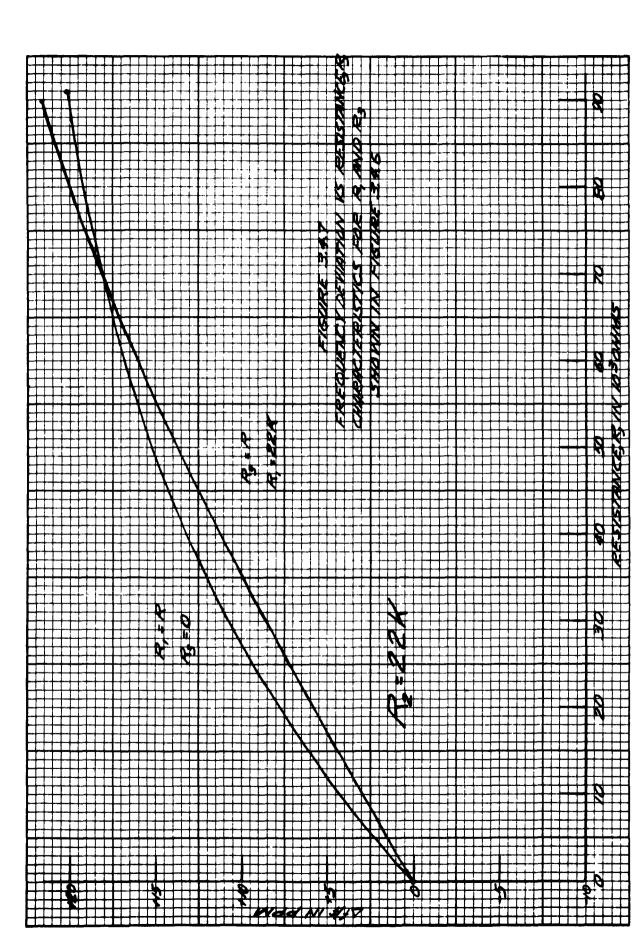
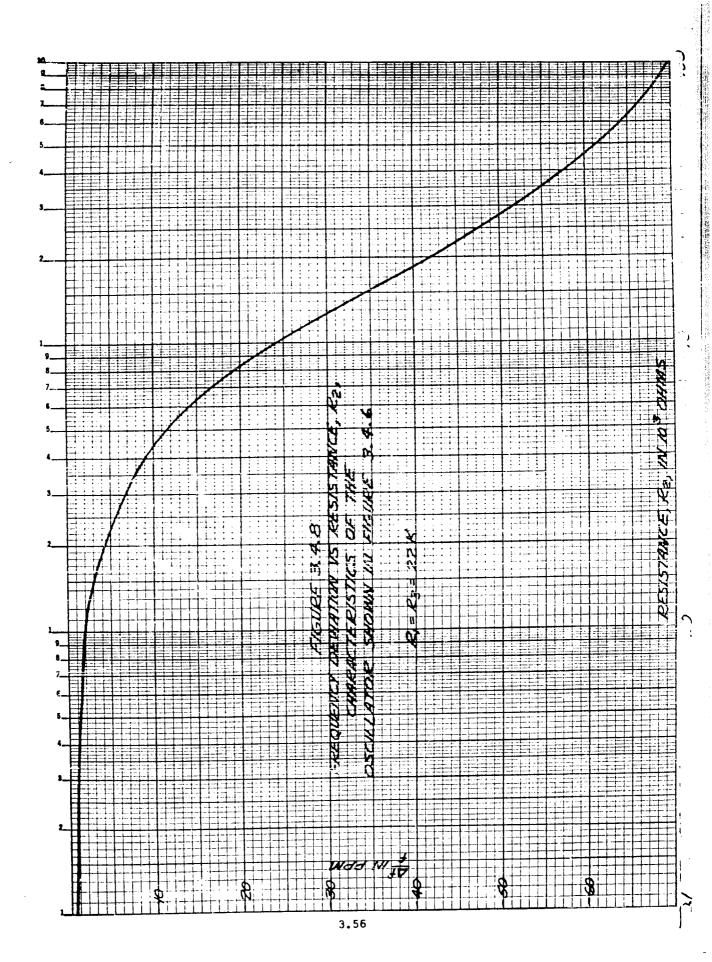


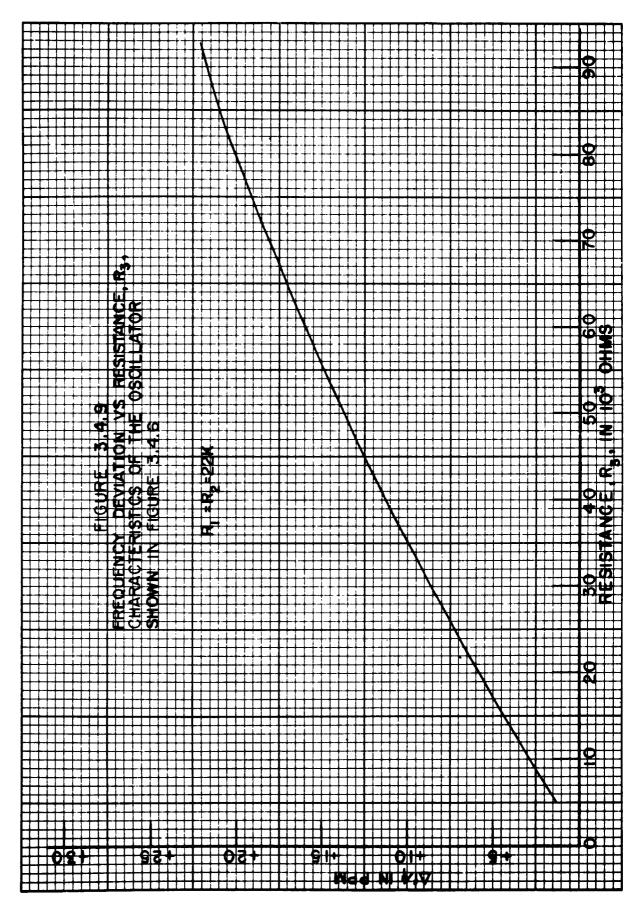
Figure 3.4.6

 $R_3$ , was used.  $R_3$  is connected in series with the decoupling resistor,  $R_c$ . For some particular crystal frequency-temperature characteristics, it seems that the use of  $R_3$  for compensation instead of  $R_1$  provides a simpler approach to compensation. Figure 3.4.7 is a comparison of the  $\Delta f/f$  versus R characteristics of  $R_1$  and  $R_3$ . Figures 3.4.8 and 3.4.9 are plots of the  $\Delta f/f$  versus  $R_2$  and  $R_3$ characteristics of the oscillator shown in Figure 3.4.6. These curves were the ones used for obtaining the curves shown in Figure 3.4.5.

Curve (a), shown in Figure 3.4.5, is the frequency versus temperature characteristics of the uncompensated oscillator of Figure 3.4.6. Curve (b) is a plot of the frequency versus temperature characteristics of the oscillator using the compensation networks shown, but the crystal frequency-temperature







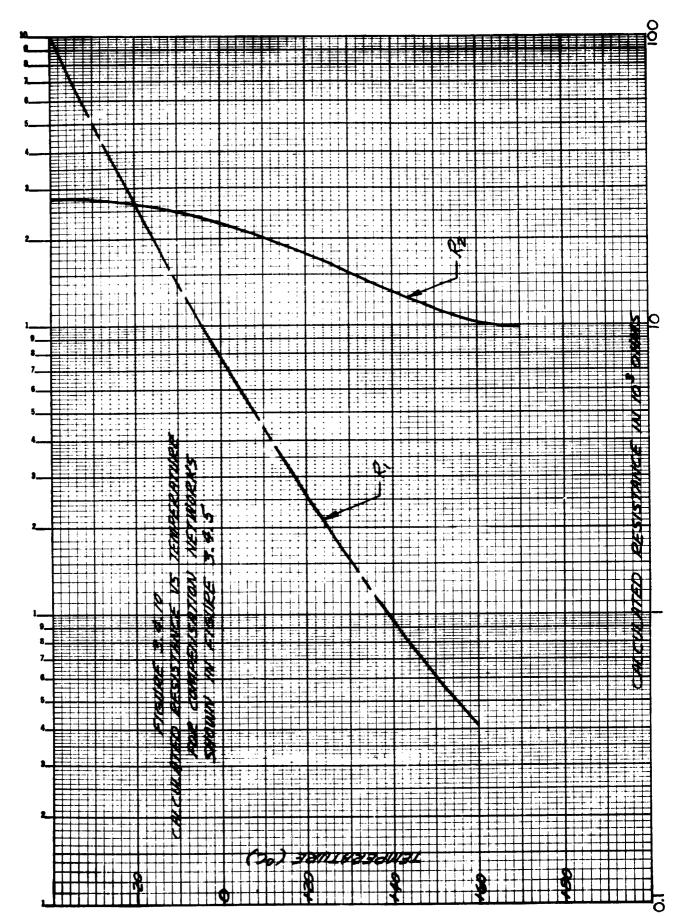
characteristics eliminated. Curve (c) is a plot of the resultant characteristics of the compensated oscillator.

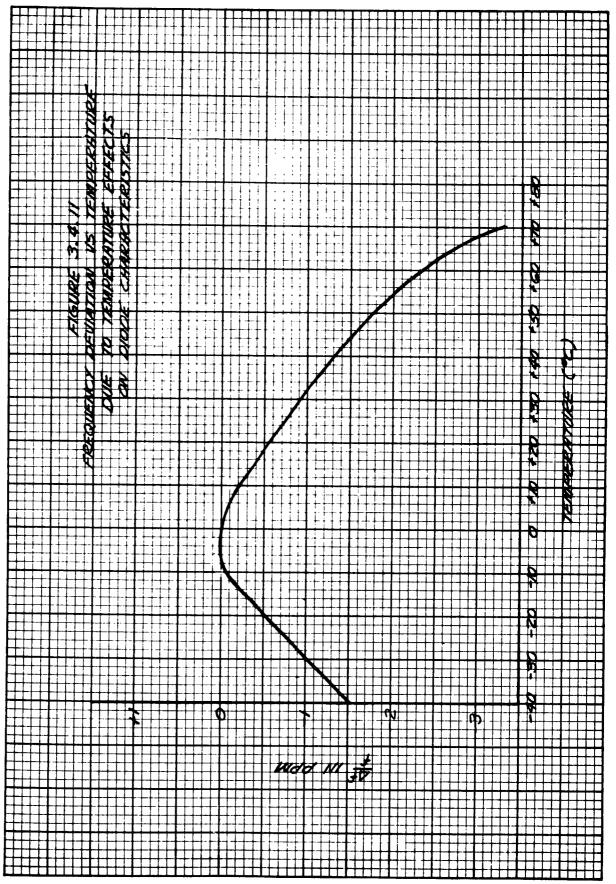
As can be seen from the compensation networks shown in Figure 3.4.5, the networks are a simple combination of a total of two thermistors and three resistors. Figure 3.4.10 is a plot of the calculated R versus temperature characteristics of the two networks.

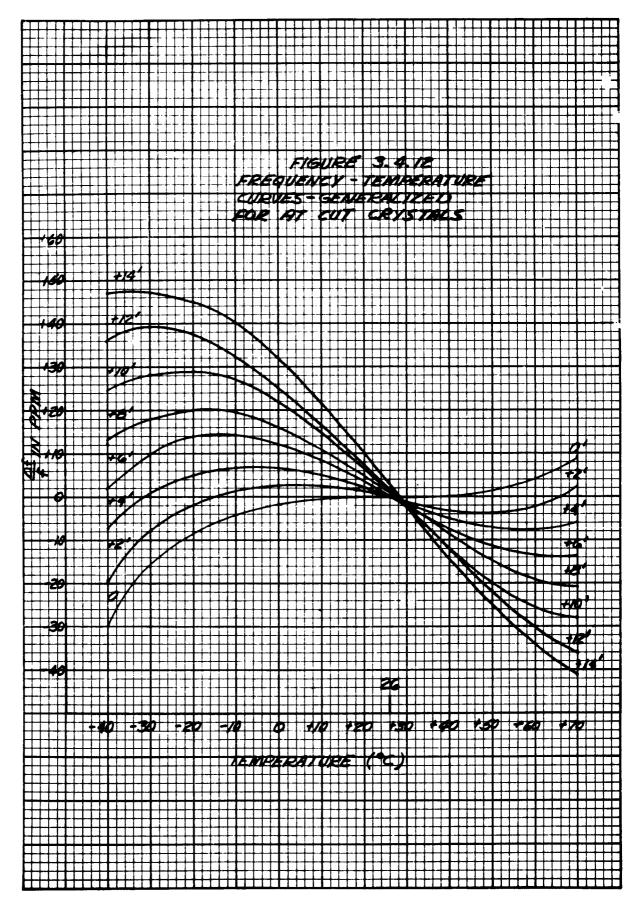
The results of tests that have been conducted indicate that the diode has a temperatue effect upon the compensation curves. Figure 3.4.11 is a frequency deviation versus temperature curve that resulted from a capacitor-diode compensation network with a constant bias. The results from the tests so far are not conclusive, but it appears that some diode types have less temperature effect than others.

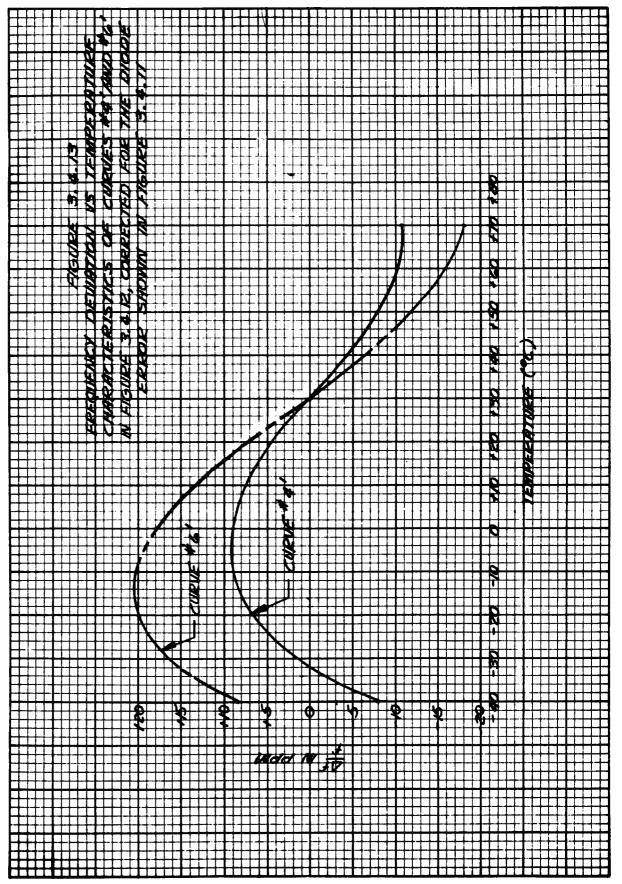
The problem of compensating crystals with different frequency-temperature characteristics using the capacitor-diode compensation method is being investigated. Two crystal frequency versus temperature curves were taken from the reference chart of crystal characteristics shown in Figure 3.4.12, Curves #4 and #6, and the error curve in Figure 3.4.11 was added to these two curves. Figure 3.4.13 shows the resulting frequency-temperature characteristics.

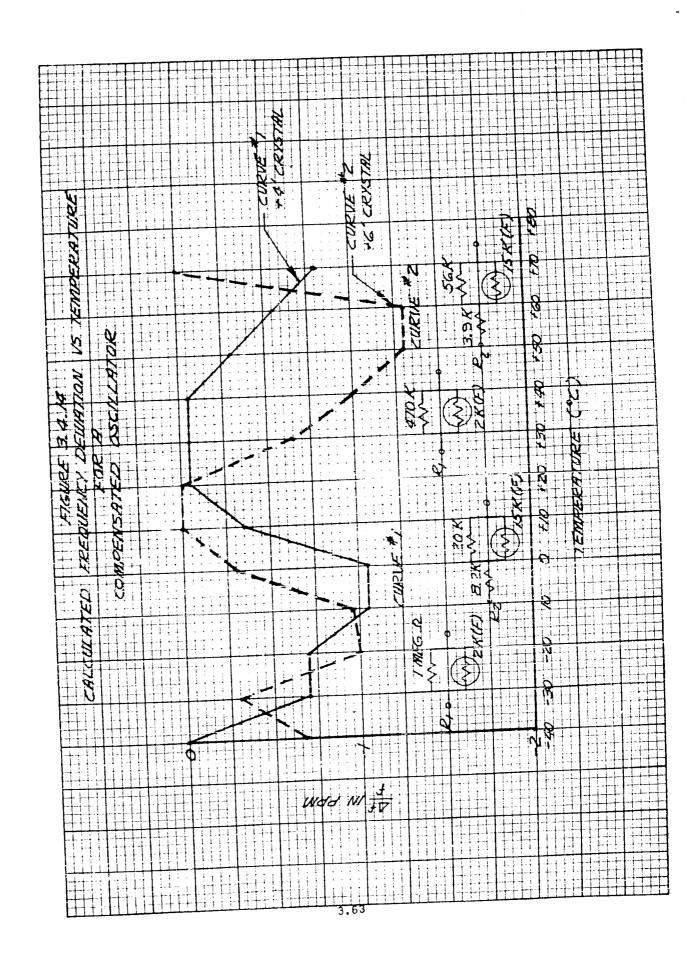
The two curves shown in Figure 3.4.13 were assumed to be the curves of the oscillator in Figure 3.4.6. The characteristics were then compensated for by using the pullability curves of Figure 3.4.8 and 3.4.9. The results of the compensation procedure are shown in Figure 3.4.14. The networks required for compensation are also shown. The maximum deviation for both of the compensated oscillator curves is almost identical and this was achieved by changing only two resistors in the compensation network. The thermistors did not have to be changed. This indicates that a compensation network configuration and the thermistors could be specified for a certain





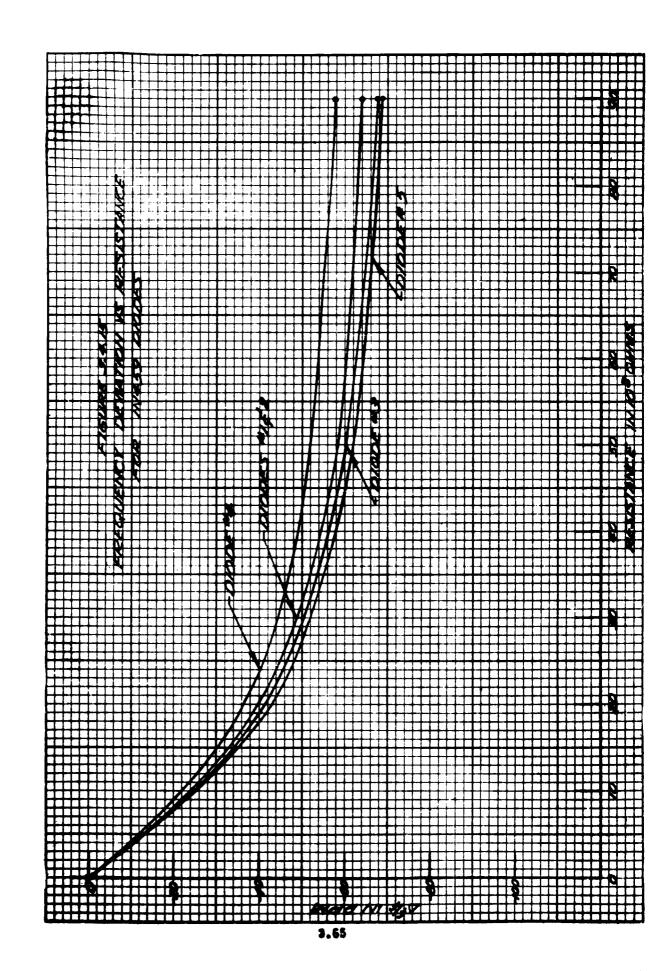






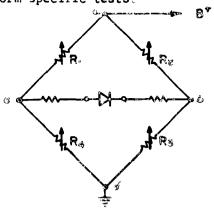
spread of crystal characteristics and that changing fixed resistor values could compensate for the corresponding spread in crystal characteristics.

A number of types of diodes have been tested for uniformity in compensation characteristics. Figure 3.4.15 is a plot of  $\Delta f/f$  versus R for a sample lot of 1N459 diodes. This diode type exhibited the best results from on ediode to another. A lot of ten 1N459 diodes was tested. The five shown in Figure 3.4.15 are typical and the other five diode's characteristics fell within the two extremes shown.



## 3.5 Diode Voltage Control and Switching

The voltage and current control bridge circuit analysis was presented in a previous section. A test circuit was built to empirically determine the characteristics of the zener diode controlled bridge. Figure 3.5.1 is a schematic of this circuit. The zener diodes were placed across the appropriate resistors to perform specific tests.



BRIDGE CIRCUIT FIGURE 3.5.1

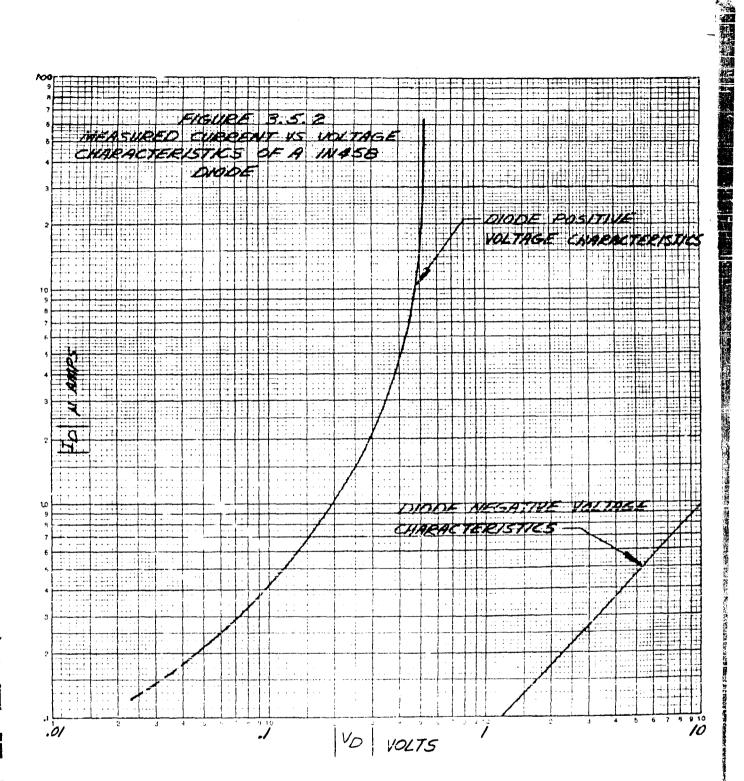
One of the problems that was anticipated using zener diodes as voltage limiters is that if the resistance of the circuit or the resistance in series with the zener is too large, then the zener voltage may not take control fast enough because of the limited current through the zener diode. The other extreme, when the resistance of the circuit is too small, may also be a problem. If the resistance is too small, an excessive amount of power will be drawn from the power supply. The zener increases the current drain from the power supply when it is biased well over the zener knee on its zener characteristic curve because a small increase in voltage causes a very large amount of additional current to be drawn through the zener.

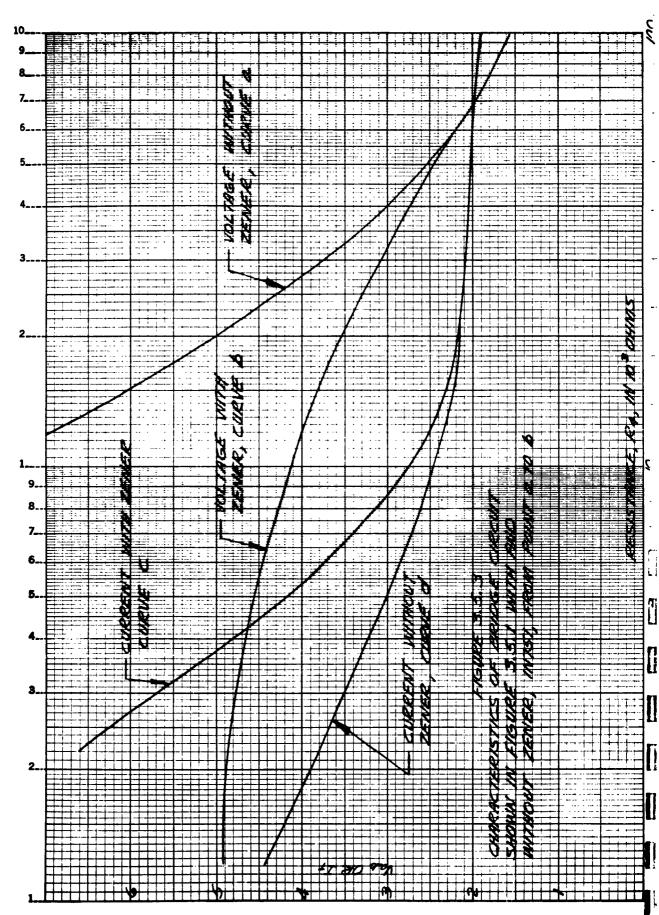
Another point that was anticipated to have an effect on the voltage control of the zener diode is when the diode is forward biased. The current

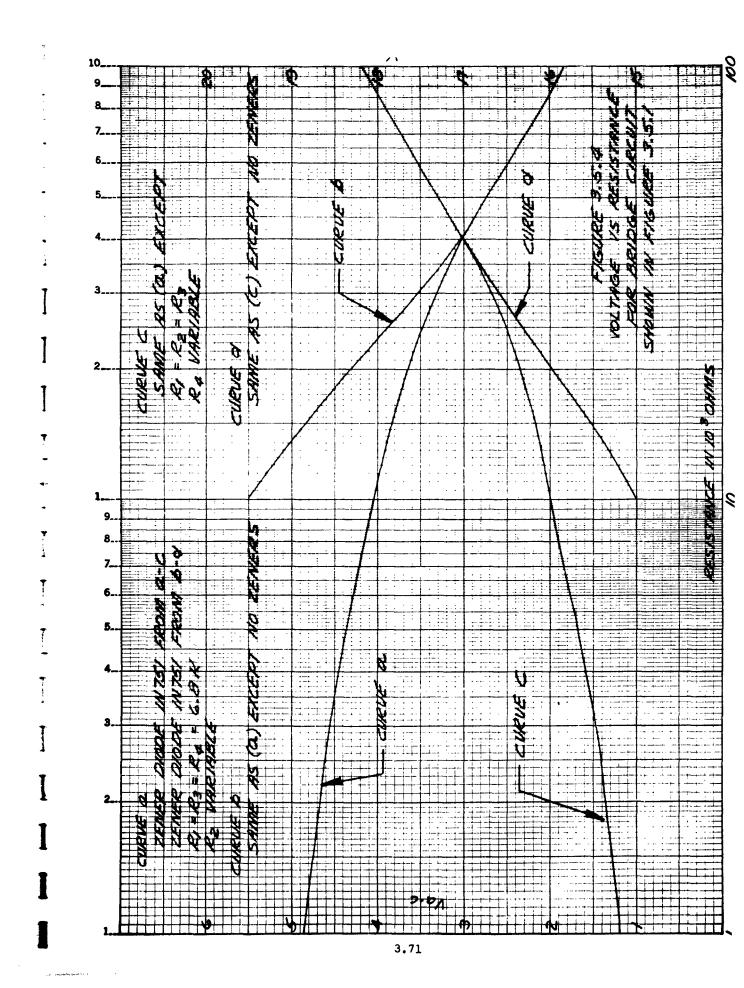
through the diode may upset the relatively isolated properties of the two voltage dividers present in the bridge. The current voltage relationship of a diode is shown in Figure 3.5.2. Due to the non-symmetrical properties of the diode, the characteristics of the bridge will not be the same when the diode is forward biased as when the diode is reverse biased.

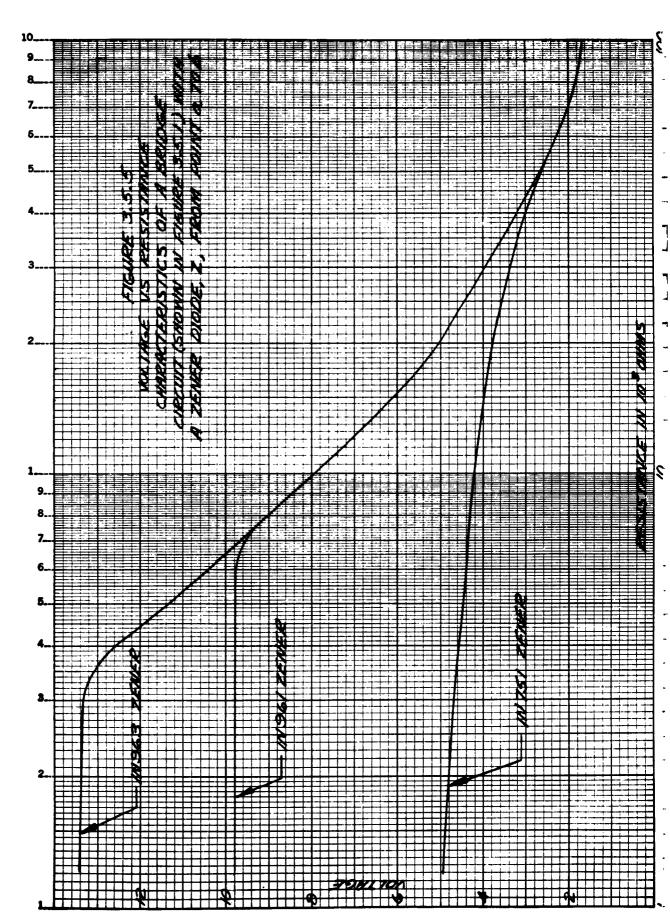
A number of bridge circuits were built using various component values and the characteristics of each were investigated. Some of the typical curves are presented in this report. Figure 3.5.1 is a schematic of the basic circuit used for the data presented in the graphs with the appropriate modifications in the circuit indicated on each graph. Figure 3.5.3 is a plot of the voltage from point (a) to point (b) in Figure 3.5.1 and the total current into the bridge circuit versus the bridge resistance  $R_{ij}$ . Curve (a) indicates the voltage versus  $R_{ij}$  relationship of the bridge without a zener diode and curve (b) indicates the voltage versus  $R_{ij}$  relationship with a 1N751 diode from point (a) to point (b). The zener has a pronounced effect on the voltage-resistance characteristics of the bridge. Curves (c) and (d) indicate the bridge current with and without the zener diode present, indicating that the current increases quite rapidly with the zener in the circuit as the resistance  $R_{ij}$  is decreased due to the zener characteristics.

Figure 3.5.4 indicates the effect of the zener on the bridge circuit when  $R_2$  and  $R_4$  are varied. The slopes of the  $V_{ac}$  versus R curves for  $R_2$  and  $R_4$  are almost identical but opposite in sign. The effect of different zener diodes on the voltage versus resistance characteristics of the bridge circuit is shown in Figure 3.5.5. The sharpness of the change in slope of the V versus R curve increases as the zener voltage of the diode increase which is quite evident in Figure 3.5.5.





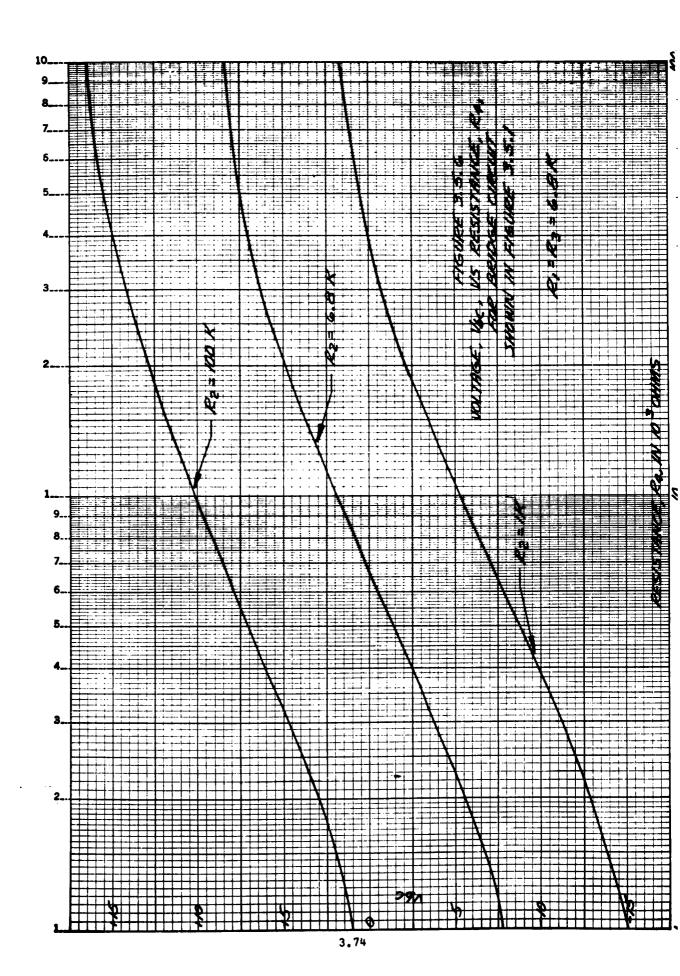


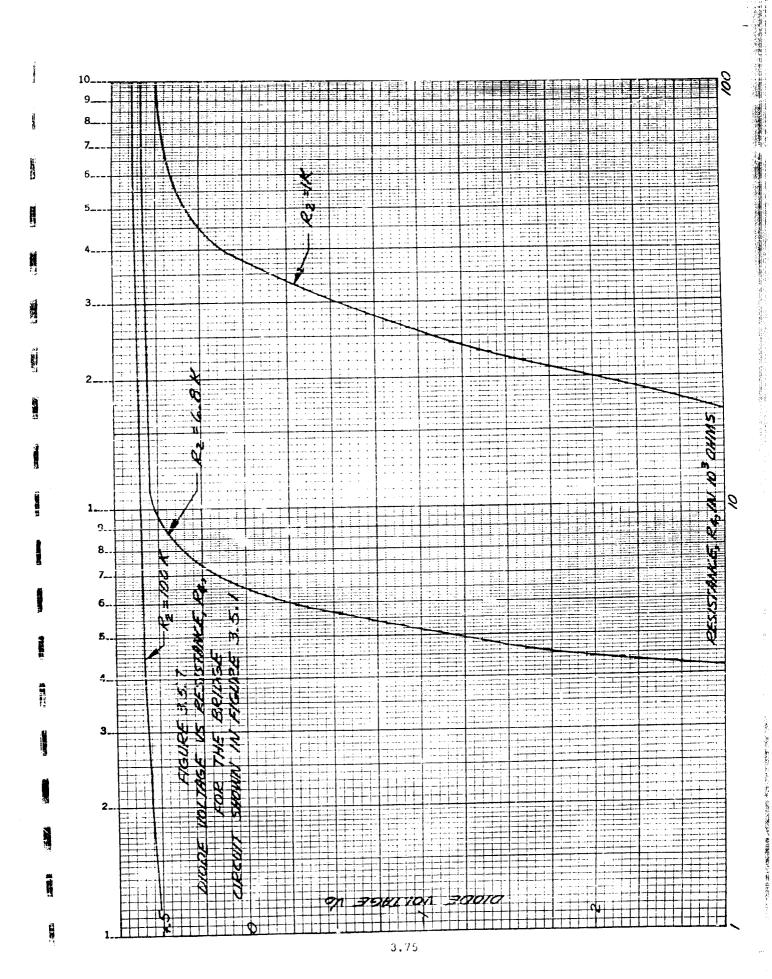


The effect of changing,  $R_2$ , on the voltage,  $V_{bc}$ , versus  $R_4$  characteristics are as shown in Figure 3.5.6. This figure illustrates the fact that for null,  $R_1R_3 = R_2R_4$ . Because the tolerance on the resistors used was 10 percent, the measured value of  $R_1$  and  $R_3$  was about 6.2K. Thus for  $R_2 = 1$  K,  $R_4 = 40$ K and  $R_4R_2$  was equal to  $4 \times 10^7$   $R_1R_3$  was about 3.97 x  $10^7$ . For  $R_2 = 6.2$  K,  $R_4$  was equal to about 6.3 K at  $V_{bc}$  equal to zero volts and  $R_2R_4 = 3.91 \times 10^7$ . So within the limits of the measured resistance values, the equation  $R_1R_3 = R_2R_4$  was satisfied at the points where  $V_{bc}$  was equal to zero volts.

Figure 3.5.7 shows the actual voltage across the diode versus the resistors  $R_{ij}$  as a function of  $R_{ij}$ . This plot corresponds to the ones given in Figure 3.5.6, but indicates diode voltage instead of the bridge voltage,  $V_{bc}$ . The characteristic of the diode is quite obvious as the voltage across it goes positive. The diode has a very sharp break point at a positive voltage, about 0.5 volts.

Figure 3,5,2 shows the calculated V versus I curves for the diode used in the bridge for Figure 3,5,6 and 3.5.7.





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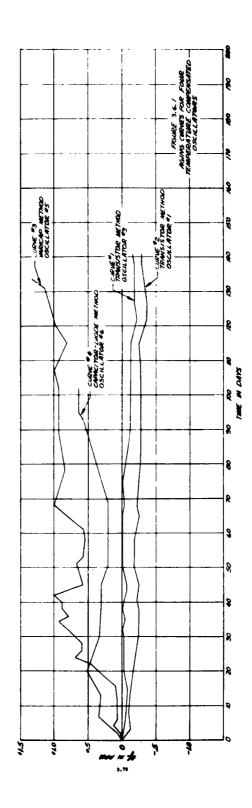
#### 3,6 Oscillator Aging Tests

The aging tests on four compensated oscillators that was started during the first quarter is being continued. The aging data compiled to this time is very favorable. Very little aging has been observed in any of the oscillators. Some of the oscillators vary from one day to the next, but this is because the ambient temperature is not closely controlled when readings are taken. The change in ambient temperature will have an effect on the frequency of the oscillators because the compensation of all of the oscillators is not optimum at room temperature. Even though the readings taken from one time to the next may vary, if the curves are averaged over a period of time, it can be seen that the individual readings vary around a certain point or are varying at some rate with time. The aging data for the oscillators being tested is shown in Figure 3.6.1. Some of the original oscillators have been taken off of the aging tests. The data acquired from these oscillators was too erratic because the compensation was not adequate for the variations of room temperature. The changes of room temperature from day to day caused such large excursions in frequency that the aging effects were not apparent.

The method used to compensate each of the oscillators on the aging test is given in the table below.

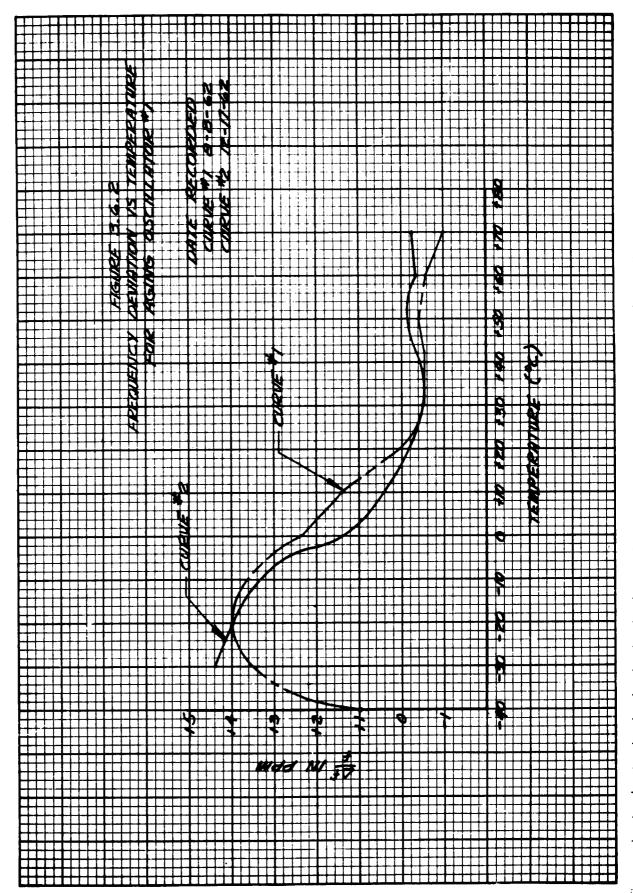
| <u>Oscillator</u> | Figure No. | Compensation Method |
|-------------------|------------|---------------------|
| #1                | 3.6.2      | Transistor          |
| #3                | 3,6,3      | Transistor          |
| #5                | 3.6.4      | Varicap             |
| #6                | 3.6.5      | Capacitor-Diode     |

Previous reports have the complete circuit diagrams for each of these compensated oscillators. The compensated oscillators that are being used for

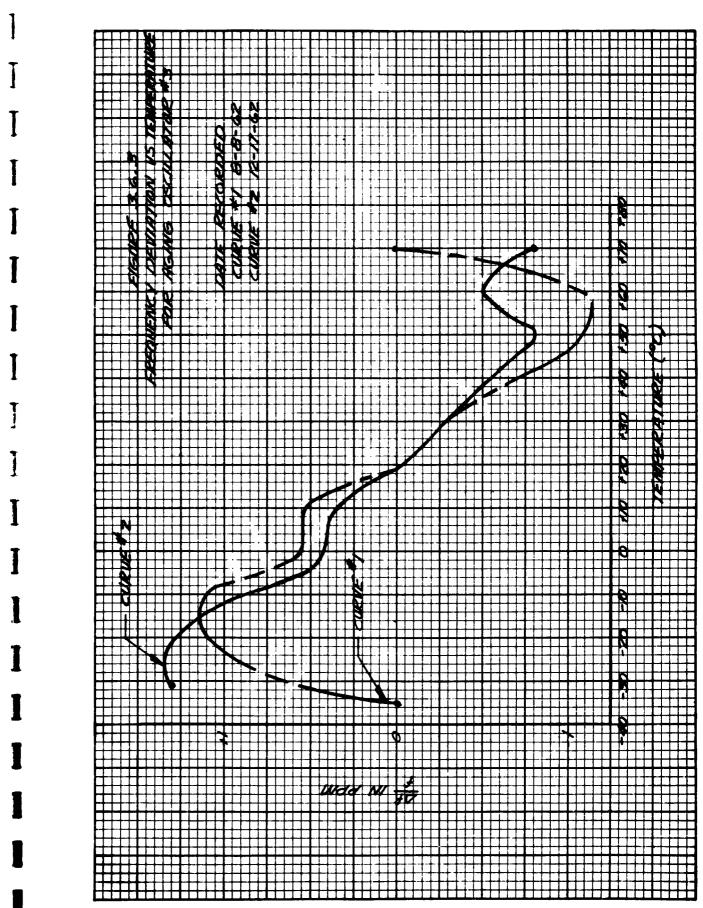


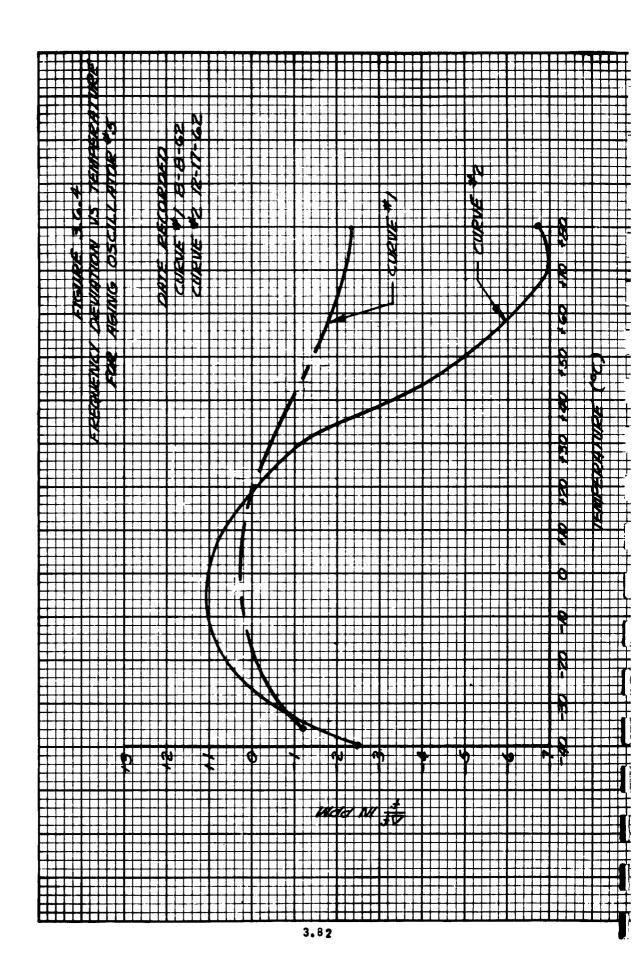
aging tests were not constructed from special components. The compensating networks were constructed using 10%, 1/10 watt carbon resistors and 10% thermistors. The biasing resistors for the oscillator transistor were also 1/10 10% carbon resistors. No special consideration was given to the temperature coefficient or stability characteristics of the components. Therefore some of the aging of the oscillators that has been observed may be due to changes in circuit component parameters other than the crystal. Future compensated oscillators that are intended for aging tests will be made from the best components available with special emphasis placed on component stability with time. This should produce aging characteristics for the oscillator that are similar to those of the crystal.

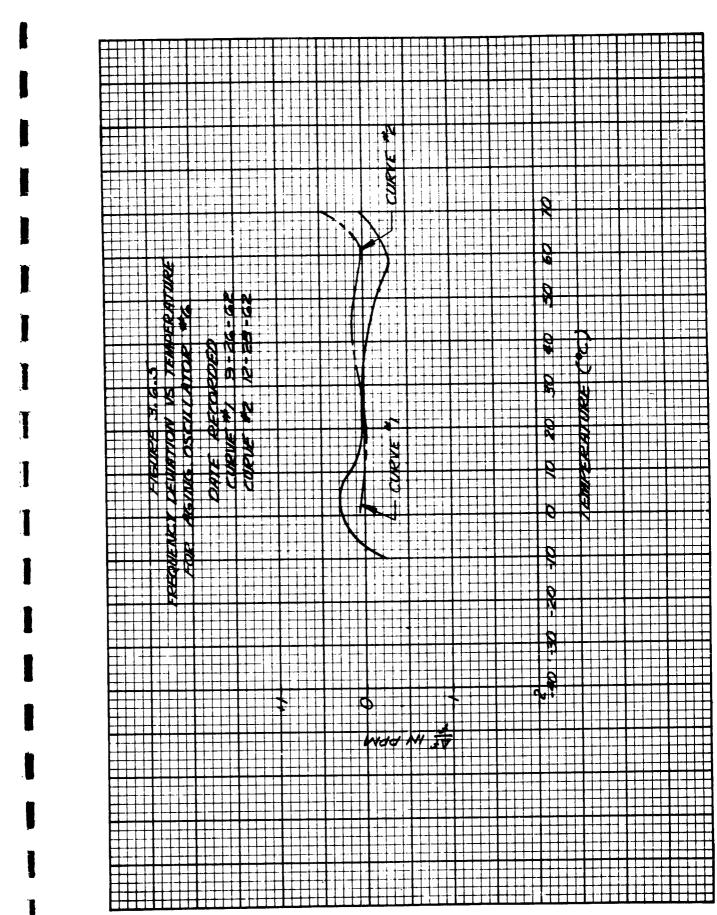
The aging oscillators were temperature cycled once during the second quarter of this contract. Figure 3.6.2, 3.6.3, 3.6.4 and 3.6.5 compare the original frequency-temperature curves to the curves taken during the aging tests. The frequency-temperature curves obtained during the second cycling agree very well with the original frequency-temperature curves that were obtained. The errors that are present between the two curves in each figure, except Figure 3.6.4, are very likely due to small temperature differentials. Also, if some the readings, either for the original curves, were taken before the temperature transient was completely gone, then apparent errors in the frequency at a given temperature will be observed. Until more temperature cycling tests are performed, it will be difficult to determine whether the errors in frequency that were observed were actual or due to error in temperature or to temperature transient.



3.80







The error between the two curves in Figure 3.6.4 cannot be explained in the above manner. It appears as if the thermistor controlling the high temperature end has either been shorted or open circuited. This is the only reasonable explanation for the difference between the two curves. At the completion of the aging curves, oscillator #5 will be dismantled and the cause for the error determined.

#### 4,1 Conclusions

The compensation methods that appear to be the most promising for very accurate frequency-temperature compensation of crystal oscillators are the varicap and capacitor diode method. The binistor method has not been thoroughly evaluated because of the lack of appropriate binistor characteristics, therefore, for the present, the binistor method is not feasible. The transistor method requires more involved techniques than does the varicap and capacitor diode methods, although the aging characteristics of the transistor compensated oscillators appear to be the best. Aging data on a larger sample of compensated oscillators will have to be compiled before conclusive results are obtained.

The variety of techniques whereby control networks can be devised presents a selection of many different approaches to compensation of an oscillator using the same compensation method. Each control network seems to have certain advantages over other types for various conditions, such as the crystal angle of cut, temperature range, etc.

The method presented that eliminates the effect of B+ voltage variations on the frequency of the oscillator is very applicable. This technique, if proven to be completely satisfactory, will eliminate the need for accurately regulated voltages.

## 5.1 Personnel Associated with the Project

The following Engineering personnel have engaged in various activities in conjunction with the project during the report period.

#### PROJECT DIRECTOR

Dr. Darrell E. Newell, Ph.D.

Approximate Hours - 18

Education:

BSEE, Iowa State University, 1952 MSEE, State University of Iowa, 1956

Ph.D. in EE, State University of Iowa, 1958

Experience:

From June 1961 to present - Dr. Newell is the Senior Engineer in charge of research, design and development of products within the Electronics Section. Representative projects include; development of new techniques in cryogenic liquid level measurement and flow measurement for missile and space applications, preliminary development of complete propellant management system for Saturn II vehicle, development of new techniques for temperature compensation of crystal oscillators, development of a new crystal type cryogenic thermometer and other internal sponsored development projects directed towards advance applications in space and missile technology.

From June 1959 to May 1961 - Associate Professor in the Research Section of the Electrical Engineering Department at the State University of Iowa. Some of the projects under his jurisdiction included:

- 1. Study of temperature compensation circuitry for quartz crystal oscillators.
- 2. Investigation of the short-term instability of regenerated dividers.
- Investigation of mechanical refrigerator suitable for cooling quartz crystals.
- 4. Investigation of parametric amplification, oscillator, multiplication and conversion.
- 5. Nuclear Gyroscope Projects

From 1952 to 1959 - Dr. Newell was employed by Collins Radio Company, Cedar Rapids, Iowa. During this period when academic endeavors were pressing he was employed as a consultant and the remaining time as a Research Engineer in charge of such projects as propagation, excitation and function generator control problems.

### 1949 to 1952 - Transmission Engineer for WOI-AM-FM-TV

#### Professional Affiliations:

- 1. Member and Officer of Institute of Radio Engineers
- 2. Registered Professional Engineer of Iowa
- 3. Member of Iowa Academy of Science
- 4. Maintains First Class Radio Television Commercial License

#### Patents:

- 1. Switching Circuitry
- 2. Automatic Frequency Control
- 3. Frequency Stabilizing Networks

### Publications: 1.

- . "Research Modulation" published by Collins Radio Co.
- 2. "An Investigation of Noise and Function Generators" published by Collins Radio Company.

#### PROJECT ENGINEER

## Richard H. Bangert

Approximate Hours - 260

Education:

AA, Keckuk Community College, 1958 BSEE, State University of Iowa, 1961

Graduate work towards MSEE, State University of Iowa

Experience:

August 1961 to present - Mr. Bangert is the Project Engineer in charge of the Frequency Synthesis and Control Group. Projects under his direct supervision include:

- 1. Phase-Locked Frequency Dividers
- 2. Temperature Compensated Oscillators
- 3. Miniature Oscillators
- 4. Frequency Standards
- 5. 50 Megacycle Phase-Locked Loop System
- 6. Ultra-Stable Telemetering Oscillators
- 7. Research Study for Signal Corps Temperature Compensated Quartz Crystal Oscillators

February 1960 to August 1961 - Mr. Bangert worked as a graduate assistant in the Electrical Engineering Department at the State University of Iowa. Projects included; temperature compensation of quartz crystal oscillator, circuitry design for temperature compensation of quartz crystal oscillators, designed computer program for IBM 7070 to find a means of synthesizing temperature compensation networks.

Professional Affiliations: Member of Institute of Radio Engineers

Patents: 3 pending

Temperature Compensation of Quartz Crystal Oscillators

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PREQUENCY TEMPERATURE COMPENSATION TECHNIQUES
FOR QUARTZ CHYSTAL GGGLIATORS
By R. H. BANGERT Accession To. THE BENDIX CONFORATION PROFILE-CENTRAL DIVISION PROFILE-CENTRAL DIVISION PROFILE-CENTRAL DIVISION PROFILE TO THE Develor, loss fractions contraction fraction for quarts certified occuration Accession To. 1. Compensation
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Suitching Two different approaches are analyzed. The first nation (vi. ). Captulators where the first nation (vi. ). Captulators where is equalization of a back-bines diode with "respective visitions the necessal and third willings the change is one—". Stability the necessal and third willings the change is one—". Stability that paint changes, the fraction thinks of Trendships of Trendships of the Aging that prescribes and as a back-bines dides, the fifth mithed reserves changes enablated by a forward-binest dides the first partial of a separate of the contract Armed Services Technical Information Agency UNCLASSIFIED UNCLASSIFIED UNCLASSIFIED The different appearance are manipad. The first enthod uti- 3, lines the change in expections of a back-blased diodes with a valueque, the second and whird utilizes the change in cape- citames of the collector-base justine of a transitors as the bies point changes, the fourth utilizes the transitors as the bias point changes, the fourth utilizes a "bisistor" share the third justine is used as beck-bissed diode, the fifth method use the restrace changes enhibited by a foresarch-based diode and control sefected are diseased including a bridge voltage and operated enthus in applicable to obtain any set compared that is applicable to beth the various method was enthus. Report No. 2, Second Quarterly Report, 1 October to 31 December 1962, 89 pages Lending Eigeres. Contract No. Dk-38-039 SP-99722, Unclassified Report. The approaches of aircuit tochniques for temperature compensa-tion of escillators which eliminate the most for predisely con-reguling the escillator temperature environment is discussed. The approaches of circuit techniques for temperature compensa-tion of excillatore which aliainste the meed for precisaly con-texing the confillator temperature sericument is discussed. Ampart No. 2, Second Quartorly Report, 1 Outober to 31 Dec 1962, 93 pages including figures. Contract No. De-36-039 90-90782, Unclassified Report. Accession No.

THE MENDIX CONFORMTION
PROGRESS-CENTED BRYANGEST TREATMENT OF CONFIRM C PREQUENCY TRAFFACTOR CONFESSION TO POR QUARTE CATERAL OBCILLATORS by R. H. BARGERT

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